# SiGe HBT Parameter Extraction Using Mextram 505.00

by

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#### Abstract

Applications of SiGe HBT need a robust model which can accurately describe the performance of SiGe HBT at various temperatures. Circuit simulation requires accurate transistor model and reliable parameters.

This work presents SiGe HBT parameter extraction using the latest version of Mextram (Most EXquisite TRAnsistor Model) 505.00. A first generation SiGe HBT with 50 GHz cutoff frequency is used to show the extraction procedure using ADS simulator and extraction software IC-CAP.

Low current model parameters are first extracted at reference temperature, including capacitance parameters, Early effect parameters, avalanche parameters, saturation currents, from low current I - V or C - V characteristics, where self-heating is negligible. Temperature scaling parameters of these low current model parameters are then determined by fitting low current I - V at all temperatures. Next, high current model parameters at reference temperature are extracted, including series resistances, self-heating thermal resistance, epi-layer model parameters, avalanche current dependence. Simultaneous fitting of high current characteristics at all temperatures is used to determine or refine temperature scaling parameters for high current parameters. Following this strategy, the extraction results show that simulated curves are well correlated with measured data.

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# Table of Contents

At	ostract	t	ii
Ac	know	eledgments	iii
1	Intro	oduction	1
	1.1	SiGe HBT Characteristics	1
	1.2	Mextram fundamentals	3
	1.3	Overview of parameters	10
	1.4	Modeling tools of parameter extraction	21
	1.5	Measurements	22
	1.6	Temperature scaling basics	23
	1.7	Outline	25
2	Para	meter extraction strategy	26
	2.1	Grouping of parameters	26
	2.2	Extraction strategy	28
3	Para	meter initialization	31
	3.1	Parameters that can be given as a constant value	31
	3.2	Parameters estimated from measurements	35
	3.3	Parameters that need to be calculated	37
	3.4	Plots after initialization	41
4	Extra	action of Low Current Parameters	44

	4.1	Depletion capacitance				
		4.1.1	Base-emitter depletion capacitance	44		
		4.1.2	Base-collector depletion capacitance	45		
		4.1.3	Collector-substrate depletion capacitance	47		
	4.2	Avalar	nche	49		
		4.2.1	Extraction of avalanche parameters at 300 K	49		
		4.2.2	Temperature scaling of avalanche effect	53		
	4.3	Early l	Effect	54		
	4.4	DC Gu	ummel parameters	56		
		4.4.1	Extraction of forward Gummel parameters	56		
		4.4.2	Extraction of reverse Gummel parameters	58		
		4.4.3	Estimation of resistances	61		
		4.4.4	Temperature scaling of Gummel parameters	62		
		4.4.5	Estimation of $V_{dC}$	70		
	4.5	Low c	urrent output plots check	73		
5	Extra	action o	f High Current Parameters	77		
	5.1	Extrac	tion of parameters of self-heating and output characteristics at 300 K $\therefore$	77		
	5.2	Tempe	erature scaling of DC high current parameters	87		
	5.3	DC ex	traction check	93		
	5.4	Cut-of	f frequency at 300 K	96		
	5.5	Tempe	erature scaling of cut-off frequency	109		
6	Extra	action F	Results	113		
Re	feren	ces		115		

# List of Figures

1.1	Advanced SiGe HBT cross-section	1
1.2	Energy band diagrams for a Si BJT and a graded-base SiGe HBT biased in forward mode	2
1.3	The full Mextram equivalent circuit for the vertical NPN transistor	5
1.4	DC equivalent circuit for NPN transistor	6
1.5	AC equivalent circuit for NPN transistor	8
2.1	The actual temperature $T_k$ of forward Gummel measurement at 300 K	28
2.2	$I_S - T_K$	29
2.3	Parameter Extraction Strategy	30
3.1	Measured $I_C - V_{BE}$ curve	36
3.2	Plots of important characteristics at 300 K after initialization.	41
3.3	Currents at different temperature after initialization.	42
3.4	Plots of important characteristics at different temperature after initialization	43
4.1	Measured (markers) and calculated (line) BE depletion capacitance at 300 K $$ .	46
4.2	Measured (markers) and calculated (line) BC depletion capacitance at 300 K	47
4.3	Measured (markers) and calculated (line) SC depletion capacitance at 300 K $$ .	48
4.4	Simplified forward Early measurement circuit	49
4.5	Linear scale and log scale $G_{EM}$ versus $V_{CB}$ at 300 K	52
4.6	Linear scale and log scale $G_{EM} - V_{CB}$ at different temperatures	53
4.7	$F_{revEarly} - V_{EB}$ and $F_{fwdEarly} - V_{CB}$ at 300 K $\ldots \ldots \ldots \ldots \ldots \ldots$	55
4.8	Measured (markers) and simulated (line) collector current in forward Gummel measurement at 300 K	57

4.9	Measured (markers) and simulated (line) base current in forward Gummel mea- surement at 300 K		
4.10	$I_{sub} - V_{BC}$ and $I_B - V_{BC}$ in reverse Gummel measurement at 300 K $\ldots \ldots$	60	
4.11	Forward $I_C$ and $I_B$ and reverse $I_{sub}$ and $I_B$ in Gummel measurement at 300 K . 62		
4.12	$T_K$ of forward Gummel measurement at 300 K		
4.13	$T_K$ of reverse Gummel measurement at 300 K	64	
4.14	$I-V$ curves of Gummel measurement before temperature scaling and optimizing $I_{CS_sT}$ and $m_{Lr}$		
4.15	$I-V$ curves of Gummel measurement after temperature scaling and optimizing $I_{CS_sT}$ and $m_{Lr}$ , generated by parameters in Table 4.12.	68	
4.16	Measured (markers) and simulated (line) forward current gain $h_{fe}$	70	
4.17	Measured (markers) and simulated (line) forward current gain $h_{fe}$ after the extraction of $V_{dC}$ , generated by parameters in Table 4.13.	71	
4.18	$h_{fe}$ at different temperatures, generated by parameters in Table 4.14	72	
4.19	Gummel plots check after extracting parameters of $h_{fe}$ , generated by parameters in Table 4.14.	73	
4.20	Low current output characteristics at 300 K.	74	
4.21	Fitting low current output characteristics at 300 K, generated by parameters in Table 4.15.	75	
4.22	2 Gummel plots check and current gain check after extracting parameters of low current output characteristics, generated by parameters in Table 4.16		
4.23	Low current output characteristics fitting, generated by parameter in Table 4.17.	76	
5.1	$V_{BE}$ - $V_{CE}$ under forced high $I_B$	79	
5.2	$T_k$ of forced high $I_B$ at 300 K	81	
5.3	$I_C$ - $V_{CE}$ and $V_{BE}$ - $V_{CE}$ plots of forced high $I_B$ at 300 K	82	
5.4	Output plots of forced high $I_B$ and forced high $V_{BE}$ at 300 K $\ldots \ldots \ldots$	83	
5.5	$T_k$ of forced high $V_{BE}$ at 300 K	83	
5.6	Output plots of forced high $I_B$ and forced high $V_{BE}$ at 300 K $\ldots \ldots \ldots$	84	
5.7	Gummel plots after extraction of output plots at 300 K	85	

5.8	Optimize $R_{CV}$ and $R_{CC}$ by fitting reverse Gummel plots and high current output plots together at 300 K, generated by parameters in Table 5.1	86	
5.9	Forced high $I_B$ output curves at different temperatures, generated by parameters in Table 5.2		
5.10	Gummel plots check with output curves at different temperatures, generated by parameters in Table 5.3.	89	
5.11	Low current output plots check at different temperatures	90	
5.12	Low current output plots fitting with high current output plots and forward Gummel curves at different temperatures, generated by parameters in Table 5.4	91	
5.13	Fitting $I_S$ and $I_B$ in reverse Gummel measurement with high current output curves at different temperatures, generated by parameters in Table 5.5.	92	
5.14	DC low current extraction results at 300 K	93	
5.15	Gummel plots after temperature scaling	94	
5.16	Low current output curves after temperature scaling	94	
5.17	High current output curves after temperature scaling	95	
5.18	Impact of parameter $R_E$ on output characteristics and $f_T$	98	
5.19	Impact of parameter $R_{TH}$ on output characteristics and $f_T$	99	
5.20	Impact of parameter $I_K$ on output characteristics and $f_T$	100	
5.21	Impact of parameter $I_{hc}$ on output characteristics and $f_T$	101	
5.22	Impact of parameter $a_{Xi}$ on output characteristics and $f_T$	102	
5.23	Impact of parameter $R_{CC}$ on output characteristics and $f_T$	103	
5.24	Impact of parameter $R_{CV}$ on output characteristics and $f_T$	104	
5.25	Impact of parameter $SCR_{CV}$ on output characteristics and $f_T$	105	
5.26	Impact of parameter $V_{dC}$ on output characteristics and $f_T$	106	
5.27	Extraction of $f_T$ parameters at 300 K, generated by parameters in Table 5.6 1	107	
5.28	Check Gummel curves with $f_T$ curves at 300 K, generated by parameters in Table 5.6	108	
5.29	Temperature scaling of cut-off frequency, generated by parameters in Table 5.7. 1	110	

5.30	Optimizing forward Gummel curves with output curves at multiple tempera- ture, generated by parameters in Table 5.8
5.31	Optimizing reverse Gummel curves at multiple temperature, generated by parameters in Table 5.8
6.1	Important characteristics at 300 K
6.2	Currents of Gummel measurement at different temperatures
6.3	High current characteristics at different temperatures

# List of Tables

1.1	The resistances of the equivalent circuit given in Figure 1.4	7
1.2	The currents of the equivalent circuit given in Figure 1.4	7
1.3	The charges of the equivalent circuit given in Fig. 1.5	9
1.4	Parameters of Mextram 505.00	10
1.5	New parameters of Mextram 505.00 compared to 504.12	19
1.6	The structure of Mextram 505.00 code	22
1.7	The measurement setups in this thesis	22
1.8	The temperature parameters in the temperature scaling rules of the electrical parameters.	24
2.1	A typical grouping of parameters in Mextram 505.00	26
3.1	Parameters that can be set to a constant as initial value	31
3.2	Parameters that can be estimated from measurement.	35
3.3	The layout and process quantities	37
4.1	Parameters used in base-emitter depletion capacitance extraction	45
4.2	Parameters used in base-collector depletion capacitance extraction	47
4.3	Parameters used in collector-substrate depletion capacitance extraction	49
4.4	Parameters used in avalanche factor extraction.	52
4.5	Temperature scaling parameter of avalanche factor.	53
4.6	Parameters used in Early effect extraction.	56
4.7	Parameters used in forward $I_C$ in Gummel measurement	57
4.8	Parameters used in forward $I_B$ in Gummel measurement	59
4.9	Parameters used in reverse Gummel measurement.	61

4.10	Resistances estimated in Gummel measurement	61
4.11	Temperaure scaling parameters of Gummel characteristics	66
4.12	Parameters used in temperature scaling parameter extraction of Gummel char- acteristics, used to gerenate Figure 4.15.	69
4.13	Parameters used in fitting $h_{fe}$ , used to generate Figure 4.17	71
4.14	Temperature scaling parameters optimized here, used to generate Figure 4.18 and Figure 4.19.	72
4.15	Parameters used to fit low current output curves, used to generate Figure 4.21.	74
4.16	Temperature scaling parameters used in fitting low current output curves, used to generate Figure 4.22.	74
4.17	Parameter $I_{TOavl}$ used to generate Figure 4.23	75
5.1	Parameters extracted from high current output curves and reverse currents in Gummel measurement, used to generate Figure 5.8	86
5.2	Temperature scaling parameters used in fitting high current output curves to generate Figure 5.9.	88
5.3	Temperature scaling parameters extracted from Figure 5.10	88
5.4	Parameters used in low current output plots fitting with high current output plots and forward Gummel curves at different temperatures, used to generate Figure 5.12	90
5.5	Parameters used in fitting $I_S$ and $I_B$ in reverse Gummel measurement with high current output curves at different temperatures, extracted from Figure 5.13	90
5.6	Parameters extracted from fitting cut-off frequency curves, high current output curves and $h_{fe}$ , as shown in Figure 5.27.	97
5.7	Parameters used in temperature scaling of cut-off frequency, to generate Figure 5.29	109
5.8	Temperature scaling parameters optimized with high current output curves and Gummel curves, used to generate Figure 5.30 and Figure 5.31.	111

#### Chapter 1

#### Introduction

# 1.1 SiGe HBT Characteristics

The first transistor was invented by W. Shockley, J. Bardeen and W. Brattain in 1947. Since then, the technology of bipolar junction transistors (BJTs) has been growing rapidly. The silicon-germanium heterojunction bipolar transistor (SiGe HBT) is the first practical bandgap engineering device realized in silicon, and it further improves the performance of bipolar transistors. SiGe HBT device inherits the structure from the advanced Si BJT [1] as shown in Figure 1.1 [2].



# Figure 1.1: Advanced SiGe HBT cross-section

The device has the following features:

- $N^+$  poly-emitter contact
- $P^+$  poly-base contact
- $N^+$  local collector implant
- $\bullet$  Buried  $N^+$  sub-collector
- Deep trench isolation

SiGe HBT is typically formed by adding Ge during the base region's growth. The fundamental principle of SiGe HBT is illustrated by the band diagram shown in Figure 1.2. It shows the difference of the base energy band diagrams between Si BJT and SiGe HBT at identical forward bias. Here we only consider an ideal, graded base SiGe HBT with constant doping in each region. The Ge content increases linearly from zero concentration at emitter-base (EB) junction to some maximum concentration near collector-base (CB) junction, and then rapidly decreases to zero [3]. The figure also shows that SiGe base has a smaller bandgap than that of Si. Actually, SiGe alloys can produce an energy bandgap reduction of approximate 7.5 meV for each 1 percent of Ge introduced [4].



Figure 1.2: Energy band diagrams for a Si BJT and a graded-base SiGe HBT biased in forward mode

The energy band diagram also shows that Ge-profile is graded. Referred to the base bandgap of Si, the bandgap difference at EB junction is  $\Delta E_{g,Ge}(x = 0)$ , the bandgap difference at CB junction is  $\Delta E_{g,Ge}(x = W_b)$ . Hence a Ge-induced bandgap grading over the neutral base is obtained as  $\Delta E_{g,Ge}(grade) = \Delta E_{g,Ge}(x = W_b) - \Delta E_{g,Ge}(x = 0)$ . Bandgap grading improves the performance of a transistor in many aspects. For instance, it causes a reduction of base transit time, which gives a higher  $f_T$ . It also increases the electron injection in the base so that the current gain  $\beta$  is increased. Furthermore, SiGe HBT has a higher base doping, which reduces the base resistance [5].

#### 1.2 Mextram fundamentals

Compact models are physics-based models that use a set of equations and parameters to describe transistor electrical characteristics. These models must be sufficiently simple to be incorporated in circuit simulators and are sufficiently accurate to make the outcome of the simulators useful to circuit designers [6]. Mextram (Most EXquisite TRAnsistor Model) is a vertical bipolar transistor compact model which is widely used these days, it possesses many features that the well-known Ebers-Moll model and Gummel-Poon model lack [7]. Mextram has been developed for more than three decades. The first Mextram was introduced by Philips Electronics in 1985 as level 501. Then several following updates level 502, 503 and 504 were released respectively in 1987, 1994 and 2000. The current version is level 505.00, which has been released by Auburn University in 2017 [8]. Mextram is a world standard transistor model. The latest Mextram model contains descriptions for the following effects [8]:

- Bias-dependent Early effect
- Low-level non-ideal base currents
- High-injection effects
- Ohmic resistance of the epilayer
- Velocity saturation effects on the resistance of the epilayer
- Hard and quasi-saturation (including Kirk effect)

- Weak avalanche in the collector-base junction (optionally including snap-back behaviour)
- Zener-tunneling current in the emitter-base junction
- Charge storage effects
- Split base-collector and base-emitter depletion capacitance
- Substrate effects and parasitic PNP
- Explicit modelling of inactive regions
- Current crowding and conductivity modulation of the base resistance
- First order approximation of distributed high frequency effects in the intrinsic base (high-frequency current crowding and excess phase-shift)
- Recombination in the base (meant for SiGe transistors)
- Early effect in the case of a graded bandgap (meant for SiGe transistors)
- Temperature scaling
- Self-heating
- Thermal noise, shot noise and 1/f-noise

Figure 1.3 shows the full Mextram 505.00 equivalent circuit of a NPN transistor [8]. Currents and charges placed on a drawing of transistor cross section are used to show their physical origins. The figure also shows the different regions of the transistor. An additional circuit for self-heating is shown in Figure 1.3 as well. The same model can be used for PNP transistors by switching setting flags.

The circuit has some external nodes and internal nodes. The external nodes are used to connect the transistor with the rest of the world. These external nodes are the collector node C, the base node B, the emitter node E, and the substrate node S. Mextram 505.00 has 7 internal nodes.  $B_2$ ,  $C_2$  and  $E_1$  are intrinsic NPN terminals.  $B_1$  is an internal node for base resistance related parasitic effects.  $C_1$ ,  $C_3$  and  $C_4$  are internal nodes for collector resistance related parasitic effects.  $C_3$  and  $C_4$  are for distributive buried layer resistance effects and turned off by default [8].



Figure 1.3: The full Mextram equivalent circuit for the vertical NPN transistor

Figure 1.4 shows the same equivalent circuit, but with only the DC components. Instead of overlaying the components on a physical cross section, we use a counterclockwise placement of standard counterclockwise placement of the collector, base, emitter and substrate terminals, which is more familiar to circuit designers. Figure 1.4 shows the DC equivalent circuit of Mextram 505.00 while Figure 1.5 shows the AC equivalent circuit including charges. First we look at Figure 1.4.

Now we introduce the elements in the DC equivalent circuit starting with the resistances.  $R_{Cblx}$  and  $R_{Cbli}$  are resistances of buried layer. Node  $E_1$  is connected to node E via the emitter resistor  $R_E$ . The base node B is connected to the internal node  $B_2$  via a constant base resistor  $R_{Bc}$  and a variable resistor  $R_{Bv}$ . The node  $B_1$  is between these two resistors.  $R_{Bv}$  describes DC current crowding under the emitter, so it is represented by a controlled current source  $I_{B1B2}$ . Since the epilayer is lightly doped, it has its own resistance also represented by a controlled current source  $I_{C1C2}$ .

Then we introduce the currents.  $I_N$ ,  $I_{avl}$ ,  $I_{ztCB}$ ,  $I_{B1}$ ,  $I_{B2}$  and  $I_{ztEB}$  are placed between the intrinsic nodes  $B_2$ ,  $C_2$  and  $E_1$  to model the intrinsic NPN transistor.  $I_{ex}$ ,  $I_{B3}$  and  $I_{sub}$  are used



Figure 1.4: DC equivalent circuit for NPN transistor

to model the parasitic PNP transistor. The currents of parasitic PNP transistor can be further partitioned as  $XI_{ex}$  and  $XI_{sub}$ .  $I_{B1}^S, I_{B2}^S$  and  $I_{Brel}$  are used to describe the base-emitter sidewall parasitics.  $I_{sf}$  is the substrate failure current used to warn the designer that the substrate is at a wrong potential. The summaries of these resistances and currents are given in Table 1.1 and 1.2.

Next we discuss the charges present in Mextram 505.00 shown in Figure 1.5, which is obtained by adding AC elements to Figure 1.4. The charges are represented in the circuit by capacitances.

 $C_{BEO}$  and  $C_{BCO}$  are the overlap capacitances used to shown the constant capacitances between base and emitter or base and collector, due to for instance overlapping metal layers. There are five charges in the intrinsic transistor, which are  $Q_{t_E}$ ,  $Q_{BE}$ ,  $Q_E$ ,  $Q_{t_C}$ , and

Currents		
$R_E$	Constant emitter resistance	
$R_{Bc}$	Constant base resistance	
$R_{Cc}$	Collector Constant resistance	
Rcblx	Extrinsic collector buried layer resistance	
Rcbli	Intrinsic collector buried layer resistance	

Table 1.1: The resistances of the equivalent circuit given in Figure 1.4.

Curren	ts		
$I_N$	$I_N$ Main current		
I <sub>avl</sub>	Avalanche current		
I <sub>ztCB</sub>	Collector-base junction tunneling current		
$I_{B_1}$	Ideal forward base current		
$I_{B_2}$	Non-ideal forward base current		
$I_{ztEB}$	Emitter-base junction tunneling current		
$I_{ex}$	Extrinsic reverse base current		
$I_{B_3}$	Non-ideal reverse base current		
Isub	Substrate current		
$XI_{ex}$	Extrinsic reverse base current		
XI <sub>sub</sub>	Substrate current		
$I_{B_1}^S$	Ideal side-wall base current		
$I_{B_2}^{S}$	Non-ideal side-wall base current		
$I_{Brel}$	Side-wall base current for reliability modeling		
$I_{Sf}$	Substrate failure current		
$I_{C_1C_2}$	Epilayer current		
$I_{B_1B_2}$	Pinched-base current		

Table 1.2: The currents of the equivalent circuit given in Figure 1.4.



Figure 1.5: AC equivalent circuit for NPN transistor

 $Q_{BC}$ .  $Q_{t_E}$  and  $Q_{t_C}$  are almost ideal depletion charges resulting from the base-emitter and basecollector pn-junctions.  $Q_{BE}$  and  $Q_{BC}$  are referred to as junction diffusion charges.  $Q_{BE}$  is related to forward operation and  $Q_{BC}$  is related to reverse operation.  $Q_E$  is emitter neutral charge. The charge  $Q_{epi}$ , which is placed in the epilayer region in Figure 1.5, describes the epilayer diffusion charge.  $Q_{t_E}^S$  is the depletion charge of the base-emitter sidewall.  $Q_{t_S}$  is the depletion charge of the collector-substrate junction.  $Q_{ex}$  and  $Q_{tex}$  are the diffusion charge and depletion charge of extrinsic base-collector.  $XQ_{ex}$  and  $XQ_{tex}$  can be further partitioned from  $Q_{ex}$  and  $Q_{tex}$ .  $Q_{B_1B_2}$  is placed parallel to  $I_{B_1B_2}$ , used to model the charge due to AC-current crowding in the pinched base. Table 1.3 gives the summary of charges.

Charges	Charges		
$Q_{BEO}$ Base-emitter overlap charge			
$Q_{BCO}$	Base-collector overlap charge		
$Q_E$	Emitter charge or emitter neutral charge		
$Q_{t_E}$	Base-emitter depletion charge		
$Q_{t_E}^S$	Sidewall base-emitter depletion charge		
$Q_{BE}$	Base-emitter diffusion charge		
$Q_{BC}$	Base-collector diffusion charge		
$Q_{t_C}$	Base-collector depletion charge		
$Q_{epi}$	Epilayer diffusion charge		
$Q_{B_1B_2}$	AC current crowding charge		
$Q_{tex}$	Extrinsic base-collector depletion charge		
$XQ_{tex}$	Extrinsic base-collector depletion charge		
$Q_{ex}$	Extrinsic base-collector diffusion charge		
$XQ_{ex}$	Extrinsic base-collector diffusion charge		
$Q_{ts}$	Collector-substrate depletion charge		

Table 1.3: The charges of the equivalent circuit given in Fig. 1.5.

### 1.3 Overview of parameters

Mextram 505.00 contains 121 parameters when considering substrate and self-heating. The parameters can be classified into several groups such as general parameters like the level and the model flag, current parameters of the basic model and avalanche model, parameters of resistances and epilayer, the parameters of the depletion capacitances and the transit times. The noise and temperature scaling parameters are also included. Table 1.4 gives all the parameters of Mextram 505.00 [8]. The parameters denoted with a '\*' in the description are not used in the DC model.

#	symbol	name	units	description
1	DTA	dta	°C	Difference between local ambient and global
				ambient temperatures
2	MULT	mult		Multiplication factor
3	VERSION	version		Model level
4	TYPE	type		Flag for NPN (1) or PNP (-1) transistor type
5	T <sub>ref</sub>	tref	°C	Reference temperature. Default is $25^{\circ}C$
6	EXMOD	exmod		Flag for extended modeling of the reverse cur-
				rent gain
7	EXPHI	exphi		*Flag for distributed high-frequency effects in
				transient
8	EXAVL	exavl		Flag for extended modeling of avalanche cur-
				rents
9	EXSUB	exsub	_	Flag for extended modeling of substrate cur-
				rents
10	I <sub>s</sub>	is	А	CE saturation current
11	N <sub>FF</sub>	nff		Non-ideality factor of forward main current
12	N <sub>FR</sub>	nfr		Non-ideality factor of reverse main current

Table 1.4: Parameters of Mextram 505.00

#	symbol	name	units	description	
13	l <sub>k</sub>	ik	A	CE high injection knee current	
14	$V_{er}$	ver	V	Reverse Early voltage	
15	$V_{ef}$	vef	V	Forward Early voltage	
16	I <sub>BI</sub>	ibi	А	Saturation current of ideal base current	
17	N <sub>BI</sub>	nbi		Non-ideality factor of ideal base current	
18	I <sup>S</sup> BI	ibis	А	Saturation current of ideal side wall base cur-	
				rent	
19	$N_{BI}^{S}$	nbis		Non-ideality factor of ideal side wall base cur-	
				rent	
20	I <sub>Bf</sub>	ibf	А	Saturation current of non-ideal forward base	
				current	
21	m <sub>Lf</sub>	mlf		Non-ideality factor of non-ideal forward base	
				current	
22	$I_{Bf}^S$	ibfs	А	A Saturation current of non-ideal side wall for-	
				ward base current	
23	$m^{S}_{Lf}$	mlfs		Non-ideality factor of non-ideal side wall for-	
				ward base current	
24	I <sub>BX</sub>	ibx	А	Saturation current of extrinsic reverse base cur-	
				rent	
25	I <sub>kBX</sub>	ikbx	A	Extrinsic CE high injection knee current	
26	I <sub>Br</sub>	ibr	А	Saturation current of non-ideal reverse base cur-	
				rent	
27	m <sub>Lr</sub>	mlr	v	Non-ideality factor of non-ideal reverse base	
				current	
28	X <sub>ext</sub>	xext		Part of $I_{ex}$ , $Q_{tex}$ , $Q_{ex}$ and $I_{sub}$ that depends on	
				$V_{BC_3}$ instead of $V_{B_1C_4}$	
29	I <sub>zEB</sub>	izeb	А	Pre-factor of EB Zener tunneling current	

#	symbol	name	units	description	
30	N <sub>zEB</sub>	nzeb		Coefficient of EB Zener tunneling current	
31	I <sub>zCB</sub>	izcb	А	Pre-factor of CB Zener tunneling current	
32	N <sub>zCB</sub>	nzcb		Coefficient of CB Zener tunneling current	
33	SWAVL	swavl		Switch of avalanche factor $G_{EM}$ model	
34	A <sub>avl</sub>	aavl		Ionization rate coefficient A of $G_{EM}$ when	
				swavl = 1	
35	C <sub>avl</sub>	cavl		Exponent in $G_{EM}$ model when swavl = 1	
36	I <sub>TOavl</sub>	itoavl		Current temperature parameter of avalanche	
				when swavl $= 1$	
37	B <sub>avl</sub>	bavl		Ionization rate coefficient B of $G_{EM}$ when	
				swavl = 1	
38	$V_{d_{C}avl}$	vdcavl		CB diffusion voltage dedicated for $G_{EM}$ model	
				when $swavl = 1$	
39	W <sub>avl</sub>	wavl	m	Epilayer thickness used in weak-avalanche	
				model	
40	V <sub>avl</sub>	vavl	v	Voltage determining curvature of avalanche cur-	
				rent	
41	S <sub>fH</sub>	sfh		Current spreading factor of avalanche model	
				(when $EXAVL = 1$ )	
42	R <sub>E</sub>	re	Ω	Emitter resistance	
43	R <sub>Bc</sub>	rbc	Ω	Constant part of base resistance	
44	R <sub>Bv</sub>	rbv	Ω	Zero-bias value of variable part of the base re-	
				sistance	
45	R <sub>Cc</sub>	rcc	Ω	Constant part of collector resistance	
46	$R_{cblx}$	rcblx	Ω	Resistance of Collector Buried Layer: extrinsic	
				part	

#	symbol	name	units	description	
47	R <sub>cbli</sub>	rcbli	Ω	Resistance of Collector Buried Layer: Intrinsic	
				part	
48	R <sub>Cv</sub>	rcv	Ω	Resistance of un-modulated epilayer	
49	$SCR_{Cv}$	scrcv	Ω	Space charge resistance of epilayer	
50	I <sub>hc</sub>	ihc	А	Critical current for velocity saturation in the	
				epilayer	
51	a <sub>xi</sub>	axi		Smoothness parameter for onset of quasi-	
				saturation	
52	V <sub>dc</sub>	vdc	V	CB diffusion voltage	
53	C <sub>jE</sub>	cje	F	*Zero-bias EB depletion capacitance	
54	$V_{d_E}$	vde	v	EB diffusion voltage	
55	PE	pe		EB grading coefficient	
56	XC <sub>jE</sub>	xcje		*Sidewall fraction of the EB depletion capaci-	
				tance	
57	C <sub>BEO</sub>	cbeo	F	*EB overlap capacitance	
58	C <sub>jc</sub>	cjc	F	*Zero-bias CB depletion capacitance	
59	$V_{d_{c}ctc}$	vdcctc	V	CB diffusion voltage of depletion capacitance	
60	Pc	pc		CB grading coefficient	
61	SWVCHC	swvchc		Switch of $V_{ch}$ for CB depletion capacitance	
62	SWVJUNC	swvjunc		Switch of $V_{junc}$ for CB depletion capacitance	
63	X <sub>p</sub>	xp		Constant part of C <sub>jc</sub>	
64	m <sub>C</sub>	mc		Coefficient for current modulation of CB deple-	
				tion capacitance	
65	XC <sub>jc</sub>	xcjc		*Fraction of CB depletion capacitance under	
				the emitter	
66	C <sub>BCO</sub>	cbco	F	*CB overlap capacitance	
67	$m_{ au}$	mtau		*Non-ideality factor of emitter stored charge	

#	symbol	name	units	description	
68	$\tau_{E}$	taue	s	*Minimum transit time of stored emitter charge	
69	$ au_{B}$	taub	s	*Transit time of stored base charge	
70	$ au_{epi}$	tepi	s	*Transit time of stored epilayer charge	
71	$ au_{R}$	taur	s	*Transit time of reverse extrinsic stored base	
				charge	
72	dEg	deg	eV	Bandgap difference over the base	
73	X <sub>rec</sub>	xrec		Pre-factor of recombination part of $I_{B_1}$	
74	X <sub>QB</sub>	xqb		Emitter-fraction of base diffusion charge	
75	K <sub>E</sub>	ke		*Fraction of $Q_E$ in excess phase shift	
76	A <sub>QB0</sub>	aqbo		Temperature coefficient of zero-bias base	
				charge	
77	A <sub>E</sub>	ae	_	Temperature coefficient of resistivity of emitter	
78	A <sub>B</sub>	ab		Temperature coefficient of resistivity of base	
79	A <sub>epi</sub>	aepi	_	Temperature coefficient of resistivity of epi-	
				layer	
80	A <sub>ex</sub>	aex	_	Temperature coefficient of resistivity of extrin-	
				sic base	
81	A <sub>C</sub>	ac	_	Temperature coefficient of resistivity of collec-	
				tor contact	
82	A <sub>CX</sub>	acx		Temperature coefficient of extrinsic reverse	
				base current	
83	A <sub>cbl</sub>	acbl	_	Temperature coefficient of resistivity of collec-	
				tor buried layer	
84	V <sub>gB</sub>	vgb	v	Band-gap voltage of base	
85	V <sub>gc</sub>	vgc	v	Band-gap voltage of collector	
86	V <sub>ge</sub>	vge	v	Band-gap voltage of emitter	
87	V <sub>gcx</sub>	vgcx	V	Band-gap voltage of extrinsic collector	

#	symbol	name	units	description	
88	V <sub>gj</sub>	vgj	V	Band-gap voltage recombination EB junction	
89	$V_{gzEB}$	vgzeb	V	Band-gap voltage at $T_{ref}$ for EB tunneling	
90	A <sub>VgEB</sub>	avgeb	V/K	Temperature coefficient of band-gap voltage for	
				EB tunneling	
91	T <sub>VgEB</sub>	tvgeb	K	Temperature coefficient of band-gap voltage for	
				EB tunneling	
92	$V_{gzCB}$	vgzcb	V	Band-gap voltage at $T_{ref}$ for CB tunneling	
93	A <sub>VgCB</sub>	avgcb	V/K	Temperature coefficient of band-gap voltage for	
				CB tunneling	
94	T <sub>VgCB</sub>	tvgcb	K	Temperature coefficient of band-gap voltage for	
				CB tunneling	
95	$dV_{g\tau_E}$	dvgte	V	*Band-gap voltage difference of emitter stored	
				charge	
96	$dA_{I_s}$	dais		Fine tuning of temperature dependence of C-E	
				saturation current	
97	t <sub>NFF</sub>	tnff	/K	Temperature coefficient of $N_{FF}$	
98	t <sub>NFR</sub>	tnfr	/K	Temperature coefficient of $N_{FR}$	
99	T <sub>Bavl</sub>	tbavl	_	Temperature scaling parameter of $B_{avl}$ when	
				swavI = 1	
100	A <sub>f</sub>	af	—	*Exponent of Flicker-noise of ideal base current	
101	A <sub>fN</sub>	afn	—	*Exponent of Flicker-noise of non-ideal base	
				current	
102	K <sub>f</sub>	kf	—	*Flicker-noise coefficient of ideal base current	
103	K <sub>fN</sub>	kfn	—	*Flicker-noise coefficient of non-ideal base cur-	
				rent	
104	K <sub>avl</sub>	kavl		*Switch for white noise contribution due to	
				avalanche	

#	symbol	name	units	description	
105	Kc	kc		*Switch for RF correlation noise model selec-	
				tion	
106	F <sub>taun</sub>	ftaun		*Fraction of noise transit time to total transit	
				time	
107	I <sub>Ss</sub>	iss	A	Saturation current of parasitic BCS transistor	
				main current	
108	I <sub>CSs</sub>	icss	A	CS junction ideal saturation current	
109	l <sub>ks</sub>	iks	A	Knee current for BCS transistor main current	
110	C <sub>js</sub>	cjs	F	*Zero-bias CS depletion capacitance	
111	V <sub>ds</sub>	vds	V	*CS diffusion voltage	
112	ps	ps		*CS grading coefficient	
113	V <sub>gs</sub>	vgs	V	Band-gap voltage of the substrate	
114	A <sub>S</sub>	as	—	Temperature coefcient of the mobility related to	
				the substrate currents	
115	A <sub>sub</sub>	asub		Temperature coefficient for mobility of minori-	
				ties in the substrate	
116	R <sub>th</sub>	rth	°C/W	Thermal resistance	
117	C <sub>th</sub>	cth	J/°C	*Thermal capacitance	
118	A <sub>th</sub>	ath		Temperature coefficient of thermal resistance	
119	$N_{FIBrel}$	nfibrel		Non-ideality factor of base current for reliabil-	
				ity simulation	
120	I <sub>SIBrel</sub>	isibrel		Saturation current of base current for reliability	
				simulation	
121	G <sub>min</sub>	gmin		Minimum conductance	

Some features of the model are optional and can be switched on or off by setting flags, which includes: a) The extended modeling of reverse behavior; b) The distributed high-frequency effects; c) The increase of the avalanche current when the current density in the epilayer exceeds the doping level; d) The increase of intrinsic base current noise with frequency and its correlation with intrinsic collector current noise; e) Additional noises from impact ionization; f) Avalanche multiplication. Compared to Mextram 504.12, Mextram 505.00 has some changes and new features listed below [8]:

- A model of CB junction tunneling current  $I_{ztCB}$  is added.
- Non-ideality factors  $N_{FF}$  and  $N_{FR}$  in forward and reverse transport current  $I_N$ , are added respectively. They are temperature dependent factors.
- Diffusion charge and diffusion capacitance expressions are modified accordingly to maintain the same transit time.
- Non-ideality factors  $N_{BI}$  and  $N_{BI}^{S}$  in ideal base current  $I_{B_1}$  and  $I_{B_1}^{S}$ , are added respectively.
- $I_{B_2}^S$ , side-wall non-ideal base current, is added.
- $I_{Brel}$ , side-wall base current for reliability modeling, is added.
- All base current components have their own saturation current and non-ideality factors where needed. Current gains (β<sub>f</sub>, β<sub>ri</sub>) are no longer used.
- Non-ideal reverse base current is now formulated the same way as forward non-ideal base current.
- 1/f noise of all ideal base currents is now calculated from  $K_f$  and  $A_f$ , and placed between  $B_2$  and  $E_1$ . 1/f noise of all non-ideal base currents is now calculated from  $K_{fN}$  and  $A_{fN}$ , and placed between  $B_1$  and  $E_1$ .
- Avalanche current  $I_{avl}$  is calculating in  $I_N$  as initiating current, and  $I_{avl}$  limits are also modulated accordingly.
- A new avalanche factor  $(G_{EM})$  model is added and used as default.

• SWAVL, a switch parameter for avalanche factor, is added.

SWAVL = 0, no avalanche current. SWAVL = 1 (default), the new avalanche factor model. SWAVL = 2, Mextram 504 avalanche model. EXAVL is meaningful only when SWAVL=2.

- $V_{d_C ctcT}$ , diffusion voltage dedicated for CB depletion capacitance, is added.
- SWVJUNC, switch for *V<sub>junc</sub>* calculation, is added. SWVJUNC = 0 (default), 1, and 2 (504).

SWVJUNC=0:  $V_{junc}=V_{B_2C_2}$ . SWVJUNC=1:  $V_{junc}=V_{B_2C_1}$ .

SWVJUNC=2:  $V_{junc}=V_{B_2C_1}+V_{xi0}$ .

• SWVCHC, switch for transition voltage width V<sub>ch</sub> in CB capacitance-voltage curve smoothing, is added. SWVCHC=0 (default) and 1 (504).

SWVCHC=0:  $V_{ch} = 0.1 V_{d_CT}$ .

SWVCHC=1: 
$$V_{ch} = V_{d_CT} \left( 0.1 + 2 \frac{I_{C_1 C_2}}{I_{C_1 C_2} + I_{qs}} \right).$$

- l<sub>ex</sub> is now corrected to describe extrinsic BC junction current as hole injection into collector (in 504, it was described as electron injection current from collector to extrinsic base which is not the case for real devices)
- $I_{KS}$  means true substrate current's knee.
- Default value of EXSUB is 1 instead of 0.
- Range of  $I_{CS_5}$  is changed from (-inf, inf) to [0.0, inf).
- $p_0^*$  and  $p_W$  are clipped to avoid convergence problems at high  $V_{CB}$ .
- $X_{ext}$  coding is improved to allow  $X_{ext} = 0$ .

To be more flexible we introduce in Mextram 505 new saturation current and knee current parameters by removing all current gain parameters. The following conversion betweeen Mextram 504 and 505 can be employed to keep the same number of these parameters;

$$\begin{split} \mathbf{I}_{\mathsf{BI}} &= \frac{\mathbf{I_s}}{\beta_f^{(504)}}\\ \mathbf{I}_{\mathsf{BX}} &= \frac{\mathbf{I_s}}{\beta_{ri}^{(504)}}\\ \mathbf{I_{\mathsf{kBX}}} &= \frac{\mathbf{I_k}}{\beta_{ri}^{(504)}} \end{split}$$

Substrate knee current parameter in Mextram 505 uses same name but different meaning as that in Mextram 504:

$$\mathsf{I_{ks}}^{(505)} = \mathsf{I_{ks}}^{(504)} \cdot \frac{\mathsf{I_{Ss}}}{\mathsf{I_s}}$$

The new parameters of Mextram 505.00 are given in Table 1.5. Note that the parameters denoted with a '\*' are not used in the DC model.

#	symbol	name	units	description	
1	N <sub>FF</sub>	nff		Non-ideality factor of forward main current	
2	N <sub>FR</sub>	nfr		Non-ideality factor of reverse main current	
3	I <sub>BI</sub>	ibi	А	Saturation current of ideal base current	
4	N <sub>BI</sub>	nbi	—	Non-ideality factor of ideal base current	
5	I <sup>S</sup> BI	ibis	А	Saturation current of ideal side wall base cur-	
				rent	
6	N <sup>S</sup> <sub>BI</sub>	nbis		Non-ideality factor of ideal side wall base cur-	
				rent	
7	I <sup>S</sup> <sub>Bf</sub>	ibfs	А	Saturation current of non-ideal side wall for-	
				ward base current	
8	m <sup>S</sup> Lf	mlfs		Non-ideality factor of non-ideal side wall for-	
				ward base current	

Table 1.5: New parameters of Mextram 505.00 compared to 504.12.

#	symbol	name	units	description	
9	I <sub>BX</sub>	ibx	A	Saturation current of extrinsic reverse base cur-	
				rent	
10	$I_{kBX}$	ikbx	А	Extrinsic CE high injection knee current	
11	m <sub>Lr</sub>	mlr	V	Non-ideality factor of non-ideal reverse base	
				current	
12	$I_{zCB}$	izcb	А	Pre-factor of CB Zener tunneling current	
13	$N_{zCB}$	nzcb		Coefficient of CB Zener tunneling current	
14	SWAVL	swavl		Switch of avalanche factor $G_{EM}$ model	
15	A <sub>avl</sub>	aavl		Ionization rate coefficient A of $G_{EM}$ when	
				swavl = 1	
16	$C_{avl}$	cavl		Exponent in $G_{EM}$ model when swavl = 1	
17	I <sub>TOavl</sub>	itoavl		Current temperature parameter of avalanche	
				when swavl $= 1$	
18	B <sub>avl</sub>	bavl		Ionization rate coefficient B of $G_{EM}$ when	
				swavl = 1	
19	$V_{d_{C}avl}$	vdcavl		CB diffusion voltage dedicated for $G_{EM}$ model	
				when $swavl = 1$	
20	$V_{d_{C}ctc}$	vdcctc	V	CB diffusion voltage of depletion capacitance	
21	SWVCHC	swvchc		Switch of $V_{ch}$ for CB depletion capacitance	
22	SWVJUNC	swvjunc		Switch of $V_{junc}$ for CB depletion capacitance	
23	K <sub>E</sub>	ke		*Fraction of $Q_E$ in excess phase shift	
24	A <sub>CX</sub>	acx		Temperature coefficient of extrinsic reverse	
				base current	
25	$V_{g_E}$	vge	V	Band-gap voltage of emitter	
26	V <sub>gcx</sub>	vgcx	V	Band-gap voltage of extrinsic collector	
27	T <sub>VgCB</sub>	tvgcb	K	Temperature coefficient of band-gap voltage for	
				CB tunneling	

#	symbol	name	units	description	
28	V <sub>gzCB</sub>	vgzcb	V	Band-gap voltage at $T_{ref}$ for CB tunneling	
29	$A_{VgCB}$	avgcb	V/K	Temperature coefficient of band-gap voltage for	
				CB tunneling	
30	t <sub>NFF</sub>	tnff	/K	Temperature coefficient of $N_{FF}$	
31	t <sub>NFR</sub>	tnfr	/K	Temperature coefficient of $N_{FR}$	
32	T <sub>Bavl</sub>	tbavl		Temperature scaling parameter of $B_{avl}$ when	
				swavl = 1	
33	A <sub>fN</sub>	afn		*Exponent of Flicker-noise of non-ideal base current	
34	$N_{FIBrel}$	nfibrel		Non-ideality factor of base current for reliabil-	
				ity simulation	
35	I <sub>SIBrel</sub>	isibrel		Saturation current of base current for reliability	
				simulation	

#### 1.4 Modeling tools of parameter extraction

Nowadays Mextram is one of the most prevalent bipolar transistor models, which can be used for the simulation of Si and SiGe bipolar transistors for both analog and digital circuit design. The accuracy of circuit simulation depends on the mathematical description of physical phenomena and the model parameters used. In this work, the parameters are extracted by using the analysis program ICCAP with simulator ADS.

Parameter extraction is a crucial part of model development, this process mathematically minimizes the difference between measured and simulated data. Mextram model equations are implemented in Verilog-A language, which is a language that is commonly used by most simulators to describe the analog behavior of devices. The SiGe HBT used in this thesis utilizes

Filename	Description
bjt505t.va	Fully defines Mextram model including
	the module and ports then loads the
	following files to calculate
frontdef.inc	Assigns values to model constants
	and defines limiting functions
parameters.inc	Passes model parameters into the
	model from the circuit. Declares
	data type and data range
variables.inc	Defines variables for internal
	equations of model
tscaling.inc	Defines temperature scaling equations
evaluate.inc	Defines all equations in Mextram

Table 1.6: The structure of Mextram 505.00 code.

the model card name of bjt505tva, which calls a Verilog-A code for a BJT including substrate terminal and self-heating modeling. The structure of the code [9] is listed in Table 1.6.

# 1.5 Measurements

For a reliable extraction of parameters, getting the measurements done over a large range of different bias conditions is very important. There are different measurement setups such as forward Early measurement, reverse Early measurement, forward Gummel measurement, reverse Gummel measurement and output characteristic measurement. An overview of the different measurement setups and bias conditions used to get the data in this thesis is shown in Table 1.7. The parameters can be extracted from appropriate measurements.

Table 1.7: The measurement setups in this thesis.	

Measurement name	Bias setting	Meas. data
Forward Early	$V_{BE} = 0.68$ V, $V_{CB} = 0 \dots 5.0$ V	$I_C, I_B$
Reverse Early	$V_{BC} = 0.65$ V, $V_{EB} = 0 \dots 1.5$ V	$I_E, I_B$
Forward Gummel	$V_{BC} = 0$ V, $V_{BE} = 0.3$ V1.2V	$I_C, I_B, I_{sub}$
Reverse Gummel	$V_{BE} = 0$ V, $V_{BC} = 0.3$ V1.2V	$I_E, I_B, I_{sub}$
$R_E$ flyback	$I_c = 1\mu A, V_{BE} = 0.8$ V1.315V	$I_E, V_{CE}$

Measurement name	Bias setting	Meas. data
$R_{Cc}$ active	$V_{BC}$ = 0.6V, $V_{BE}$ = 0.6V1.4V	$I_C, I_B, I_{sub}$
Output - characteristic	$I_B = 2.44\mu A, 13.84\mu A, 23.82\mu A,$	
	37.69µA, 57.72µA	
	$V_{CE} = 04.0$ V	$I_C, I_{sub}, V_{BE}$
Base-emitter depl. cap.	$V_{BE} = 00.55 V$	$C_{BE}$
Base-collector depl. cap.	$V_{BC} = -2.5$ V1.0V	$C_{BC}$
Substrate-coll. depl. cap.	$V_{SC} = -2.5$ V1.0V	$C_{SC}$
S-parameters	$V_{CB} = -0.5$ V, 0V, 1.0V, 2.0V	
	$V_{BE} = 0.6$ V1.1V	$I_C, I_B, $ S-pars.

#### 1.6 Temperature scaling basics

Temperature scaling parameters describe how characteristics of a transistor vary when temperature changes. This change may be due to self-heating, which can increase the local temperature of the transistor, or change of environment temperature. Table 1.8 shows temperature scaling parameters, and the electrical parameters each temperature scaling parameter affects.

The actual simulation temperature is denoted by TEMP (in °C). The temperature at which the parameters are determined is  $T_{ref}$  (also in °C). In this work  $T_{ref}$  is 26.85°C for the measurements at 300 K are used as reference to do temperature scaling extraction.

### **Conversion to Kelvin**

$$T_K = \text{TEMP} + \text{DTA} + 273.15 + V_{\text{dT}},$$
 (1.1a)

$$T_{\rm amb} = \text{TEMP} + \text{DTA} + 273.15, \tag{1.1b}$$

$$T_{RK} = T_{ref} + 273.15,$$
 (1.2)

$$t_N = \frac{T_K}{T_{RK}}.$$
(1.3)

1	$A_{QB0}$	$V_{er}, V_{ef}, I_s, R_{Bv}, \tau_B, \tau_R, dE_g$
2	$A_E$	$R_E, I_{BI}, I^s_{BI},$
3	$A_B$	$R_{Bv}, I_s, I_k \tau_B, \tau_R, \tau_E$
4	$A_{epi}$	$R_{c_v},  au_{epi},  au_R$
5	$A_{ex}$	$R_{B_C}$
6	$A_C$	$R_{C_C}$
7	$A_S$	$I_{S_S}, I_{ks}$
8	$A_{CX}$	$I_{BX}, I_{kBX}$
9	$A_{sub}$	$I_{CSs}$
10	$V_{g_B}$	$I_s, C_{j_E}, V_{d_E}, V_{er}$
11	$V_{g_C}$	$C_{j_C}, V_{d_C}, V_{d_C ctc}, X_p, I_{Br}, V_{ef}$
12	$V_{g_S}$	$I_{S_S}, I_{CSs}, C_{j_S}, V_{d_S}$
13	$V_{g_i}$	$I^s_{BF}, I^s_{SIBrel}$
14	$V_{g_{CX}}$	$I_{BX}$
15	$dV_{g\tau_E}$	$ au_E$
16	$T_{Bavl}$	$B_{avl}$

Table 1.8: The temperature parameters in the temperature scaling rules of the electrical parameters.

Note that  $V_{dT}$  is the voltage of temperature node dT shown in Figure 1.3. The value of  $V_{dT}$  contributes to the increase in local temperature. DTA is the difference between device and ambient temperatures and its default value is 0.  $T_K$  is the actual temperature of the circuit.

#### Thermal voltage

$$V_T = \left(\frac{k}{q}\right)T_K,\tag{1.4}$$

k is Boltzmann constant:

$$k = 1.38064852 \times 10^{-23} \,\mathrm{J/K},\tag{1.5}$$

q is elementary charge:

$$q = 1.6021918 \times 10^{-19} \,\mathrm{C},\tag{1.6}$$

$$V_{T_R} = \left(\frac{k}{q}\right) T_{RK},\tag{1.7}$$

$$\frac{1}{V_{\Delta T}} = \frac{1}{V_T} - \frac{1}{V_{T_R}},\tag{1.8}$$

 $V_T$  is the thermal voltage at the actual temperature  $T_K$ .  $V_{T_R}$  is the thermal voltage at reference temperature  $T_{RK}$ .

In DC low current parameter extraction at the reference temperature, the temperature rise due to self-heating is negligible. However, there is still a temperature increase when bias gets larger. Some temperature scaling parameters can be obtained from low current parameter extraction in order to provide a good estimation for high current parameter extractions. To denote a temperature scaled parameter, a capital letter 'T' is added to the subscript. For example,  $I_{kT}$  and  $R_{CcT}$  are parameters after temperature scaling.

#### 1.7 Outline

We have reviewed the background of the SiGe HBT, and given an overview of Mextram 505.00. The modeling tools are briefly introduced. The measurements required for parameter extraction and temperature scaling fundamentals are also discussed.

In chapter 2, the parameters are separated into several groups based on how they are extracted. Then an extraction strategy is proposed.

Parameter initialization is described in chapter 3. Extraction of low current parameters is presented in chapter 4. These parameters include the parameters of capacitances, the avalanche effect, Early effect, Gummel characteristics and their related temperature scaling parameters. In chapter 5, high current parameters, as well as related temperature scaling parameters are extracted from high current output characteristics and cut-off frequency. Finally, all the extraction results are shown in chapter 6.
# Chapter 2

## Parameter extraction strategy

For the sake of an accurate extraction result, a good strategy which considers the conflicts and sequences between parameters is necessary. The general strategy of parameter extraction is to separate the parameters into small groups and then extract the parameters simultaneously out of correlated measurement.

## 2.1 Grouping of parameters

As we mentioned before, some of the Mextram parameters are flag parameters which are used to switch on or off a part of the model, some are electrical parameters used to describe currents, and some are used to describe the temperature dependence of a transistor. Thus, the parameters could be classified as parameters extracted at low-injection and high-injection, of which the electrical parameters and temperature-scaling parameters could also be further separated [10]. A typical grouping of Mextram 505.00 parameters [8] is given in Table 2.1.

Tabl	e 2.1	: A	typical	grouping	; of	parameters in	n M	lextram	505.	.00.
------	-------	-----	---------	----------	------	---------------	-----	---------	------	------

Base-emitter capacitance	: $C_{j_E}$ , $p_E$ , $V_{d_E}$
Base-collector capacitance	: $C_{j_C}$ , $p_C$ , $X_p$ , $V_{d_Cctc}$
Collector-substrate capacitance	: $C_{j_S}$ , $p_S$ , $V_{d_S}$
Avalanche at small collector currents, high $V_{CB}$	$: A_{avl}, B_{avl}, C_{avl},$
	$V_{d_cavl}, T_{Bavl}$
Avalanche at high collector currents	: $I_{TOavl}$

Reverse Early effect	: $V_{er}$
Forward Early effect	: $V_{ef}$
Forward and reverse Early effect	$: dE_g$
Forward Gummel $I_C$	: $I_s, N_{FF}, I_k$
Forward Gummel $I_B$	$: I_{BI}, I^s_{BI}, I_{Bf},$
	$I_{Bf}^s, N_{BI}, N_{BI}^s, m_{Lf}, m_{Lf}^s$
Reverse Gummel $I_E$	: $N_{FR}$
Reverse Gummel $I_B$ and $I_{sub}$	: $I_{BX}$ , $I_{kBX}$ , $I_{Br}$ , $m_{Lr}$ ,
	$I_{Ss}, I_{CSs}, I_{ks}$
Giacoletto method	: $R_E$
From forward Gummel plot at large $V_{BE}$ ,	
Y-parameters, or scaling	: $R_{Bc}$ , $R_{Bv}$
Substrate current in hard saturation	: $R_{Cc}$
Geometry scaling	$: XC_{jE}, XC_{jC}$
Temperature scaling	: Temperature parameters shown
	in Table 1.8
Decrease of $V_{BE}$ for constant $I_B$ at high $V_{CE}$	: $R_{th}$
Collector current up to high $V_{CE}$	: $I_k$
From the fall-off of $h_{fe}$ and $f_T$ at high currents	: $R_{Cv}, V_{d_C}$
From the $f_T$ vs. $I_C$	: $SCR_{Cv}, I_{hc}, \tau_E, \tau_{epi},$
	$ au_B, a_{x_i}, m_{ au}, m_C$
Reverse Gummel plot at large $V_{BC}$	: $X_{ext}$

Actually, it is not realistic to extract all the Mextram model parameters from one measured transistor. For instance, the determination of geometrical scaling parameters  $XC_{jE}$  and  $XC_{jC}$  needs more devices. The parameters describing the side wall, such as  $I_{BI}^s$  and  $I_{Bf}^s$ , also need

more information about geometrical scaling and technology. Therefore, these parameters are not extracted in this work.

#### 2.2 Extraction strategy

Some of these parameters could be extracted directly from the measurement. The extraction of low-current parameters is straightforward, but the extraction of high-current parameters demands much more efforts, for many physical effects occur in this regime. In general, low-current parameters are extracted before high-current parameters. Temperature-scaling parameters are extracted when temperature variation due to self-heating and environment changing cannot be ignored.

The collector-emitter saturation current  $I_S$ , which is a temperature-sensitive parameter used to describe the collector current, is used here to show the influence of temperature variation.  $I_S$  is extracted from forward Gummel measurement. The actual temperature  $T_K$  in this measurement is increased when the bias gets larger, as shown in Figure 2.1, for the  $V_{CB} = 0$ Gummel measurement.



Figure 2.1: The actual temperature  $T_k$  of forward Gummel measurement at 300 K

 $T_K$  increases from 300 K to around 313 K in the measurement at TEMP = 300 K due to self-heating. Meanwhile, the curve of  $I_S$  -  $T_K$  is given in Figure 2.2, showing that as  $T_K$ 

increasing,  $I_S$  increases several times. The situation is much worse for high current, high voltage measurements, where self-heating is much more significant.



Figure 2.2:  $I_S - T_K$ 

Therefore, the impact of temperature variation is so significant that the temperature scaling parameters need to be extracted properly. The extraction strategy of this work is shown in Figure 2.3.

Instead of extracting temperature scaling parameters after the extraction of all the electrical parameters as described in [11], most temperature scaling parameters are estimated in low-current parameter measurement and then be optimized when extracting high-current parameters in this work. To be more detailed, we first extract parameters of depletion capacitance from C - V characteristics, then extract the electrical and temperature scaling parameters of the avalanche factor  $G_{em}$  and the parameters of Early effect in Early measurement. Next, the saturation currents are extracted and resistances are estimated from Gummel measurement, followed by their temperature scaling parameters.  $V_{dC}$  is estimated from the fall-off of forward current gain. After checking low current output plots we can start to extract high current electrical and temperature scaling parameters from high current output plots. Then we extract electrical parameters and temperature scaling parameters of cut-off frequency.



Figure 2.3: Parameter Extraction Strategy

# Chapter 3

# Parameter initialization

The first step in parameter extraction is to generate an initial parameter set. The initial values of the parameters are important because they could offer a good starting point. With the good estimation of these values, the optimizing process could be fast and accurate, and the chance of getting stuck with very unphysical parameter values is lowered.

In this section, the method of giving initial values of parameters is introduced. The parameters are separated into three categories here. One is immediately given as constant, such as LEVEL, TYPE, and flag settings. One is obtained directly from their measurements without optimizing, like  $C_{j_E}$  and  $C_{j_C}$ . The other one is calculated from layout and process data, like the knee currents and resistances.

# 3.1 Parameters that can be given as a constant value

Table 3.1 gives the parameters whose initial value is constant. Some of them are process dependent [11]. These values come from a realistic transistor [8] and are good indication of typical values.

Parameter value		remark		
TYPE 1		Flag for NPN (1) or PNP (-1) transistor type		
T <sub>ref</sub> 26.85		Reference temperature		
DTA 0		$T_{ref}$ already describes the actual temperature		

Table 3.1: Parameters that can be set to a constant as initial value

Parameter	value	remark		
EXMOD	1	Flag for extended modelling of the reverse current gain		
EXPHI	1	Flag for the distrubuted high-frequency effects in transient		
EXAVL	0	Flag for extended modelling of avalanche currents		
EXSUB	1	Flag for extended modelling of substrate currents		
SWAVL	1	Switch of avalanche factor $G_{EM}$ model		
SWVCHC	0	Switch of $V_{ch}$ for CB depletion capacitance		
SWVJUNC	0	Switch of $V_{junc}$ for CB depletion capacitance		
N <sub>FF</sub>	1			
N <sub>FR</sub>	1			
N <sub>BI</sub>	1			
I <sup>S</sup> BI	0			
$N_{BI}^{S}$	1			
m <sub>Lf</sub>	2			
$I_{Bf}^S$	0			
${\sf m}_{\sf Lf}^{\sf S}$	2			
I <sub>kBX</sub>	$14.29 \cdot 10^{-3}$			
m <sub>Lr</sub>	2			
X <sub>ext</sub>	0.63			
I <sub>zEB</sub>	0			
$N_{zEB}$	22			
I <sub>zCB</sub>	0			
N <sub>zCB</sub>	22			
A <sub>avl</sub>	400			
B <sub>avl</sub>	25			
C <sub>avl</sub>	-0.37			
$V_{d_{C}avl}$	0.1			
I <sub>TOavl</sub>	$500 \cdot 10^{-3}$			

Parameter	value	remark		
R <sub>cblx</sub>	0			
R <sub>cbli</sub>	0			
a <sub>xi</sub>	0.3			
$V_{d_E}$	0.95	Somewhat depending on process		
PE	0.4			
C <sub>BEO</sub>	0			
C <sub>BCO</sub>	0			
$m_{ au}$	1.0			
$dE_{g}$	0			
X <sub>rec</sub>				
K <sub>E</sub>	0			
X <sub>QB</sub>	1/3			
$A_{Q_{B0}}$	0.3	Somewhat depending on process		
A <sub>E</sub>	0	Somewhat depending on process		
A <sub>B</sub>	1.0	Somewhat depending on process		
A <sub>ex</sub>	0.62	Somewhat depending on process		
A <sub>epi</sub>	2.5	Somewhat depending on process		
A <sub>C</sub>	2	Somewhat depending on process		
A <sub>CX</sub>	1.3	Somewhat depending on process		
A <sub>cbl</sub>	2	Somewhat depending on process		
$V_{g_B}$	1.17			
V <sub>gc</sub>	1.18			
V <sub>gcx</sub>	1.125			
$V_{g_E}$	1.12			
$V_{g_J}$	1.15			
$V_{gzEB}$	1.15			
A <sub>VgEB</sub>	$4.73 \cdot 10^{-4}$			

Parameter	value	remark
T <sub>VgEB</sub>	636	
$V_{gzCB}$	1.15	
A <sub>VgCB</sub>	$4.73 \cdot 10^{-4}$	
T <sub>VgCB</sub>	636	
$dV_{g\tau_E}$	0.05	
$dA_{I_{s}}$	0	
t <sub>NFF</sub>	0	
t <sub>NFR</sub>	0	
T <sub>Bavl</sub>	$500 \cdot 10^{-6}$	
A <sub>f</sub>	2	
A <sub>fN</sub>	2	
K <sub>f</sub>	$20 \cdot 10^{-12}$	
K <sub>fN</sub>	$20 \cdot 10^{-12}$	
K <sub>avl</sub>	0	
K <sub>C</sub>	0	
F <sub>taun</sub>	0	
I <sub>CSs</sub>	0	
$V_{d_S}$	0.62	Somewhat depending on process
ps	0.34	
$V_{g_S}$	1.2	
A <sub>S</sub>	1.58	Somewhat depending on process
$A_{sub}$	2.0	Somewhat depending on process
R <sub>th</sub>	1000	
C <sub>th</sub>	$3.0 \cdot 10^{-9}$	
A <sub>th</sub>	0	Somewhat depending on process
I <sub>SIBrel</sub>	0	
$N_{FIBrel}$	2	

Parameter	value	remark
$G_{min}$	$1.0 \cdot 10^{-13}$	

The resistances  $R_{Cblx}$  and  $R_{Cbli}$  have values of zero, which means the internal node  $C_1$  is connected directly to the extrinsic node C via constant collector resistor  $R_{Cc}$ .

### 3.2 Parameters estimated from measurements

Table 3.2 shows the parameters whose initial value are estimated from measured data. The methods of getting these initial values are also given [11].

Take  $C_{jE}$  to explain the method [12].  $C_{jE}$  is used to describe base-emitter depletion capacitance. When  $V_{BE} < V_{dE}$ , the capacitance  $C_{BE}$  is given as:

$$C_{BE} = \frac{C_{jE}}{(1 - \frac{V_{BE}}{V_{dE}})^{p_E}},$$
(3.1)

clearly, when  $V_{BE} = 0$ , we have  $C_{BE} = C_{jE}$ . Therefore the initial value of  $C_{jE}$  is obtained.

The saturation currents are very important and they can be easily estimated from measurement data, so we explain their initialization here. Ignoring Early effect, currents can be estimated as:

$$I = I_{sat} \exp(\frac{V}{V_T}), \tag{3.2}$$

Param	Way of extraction
$C_{jE}$	Zero bias values of base-emitter capacitance
$C_{jC}$	Zero bias values of base-collector capacitance
$C_{jS}$	Zero bias values of substrate-collector capacitance
$R_E$	Numerical derivative in $R_E$ -flyback measurement
$V_{er}$	Numerical derivative in reverse-Early measurement
$V_{ef}$	Numerical derivative in forward-Early measurement
$I_S$	From forward-gummel collector current without Early effect
$I_{BI}$	From forward-gummel base current
$I_{Ss}$	From reverse-gummel substrate current without Early effect
$I_{BX}$	From reverse-gummel base current
$\tau_E, \tau_B$	$1/[10 \pi \max(f_T)]$

Table 3.2: Parameters that can be estimated from measurement.

 $I_{sat}$  is the saturation current of I, V is the corresponding control voltage,  $V_T$  is thermal voltage. Then the saturation current can be expressed as:

$$I_{sat} = \frac{I}{\exp\frac{V}{V_T}}.$$
(3.3)

Note that logarithm scale I needs to be linearly proportional to V when estimating  $I_{sat}$ . It is pretty easy to find this bias region when we look at I-V plots. Take the initilization of collector saturation current  $I_S$  for example. Neglecting Early effect, the collector current can be given as:

$$I_C = I_S \exp \frac{V_{BE}}{V_T},\tag{3.4}$$

from this expression we can have  $I_S$  as:

$$I_S = \frac{I_C}{\exp\frac{V_{BE}}{V_T}}.$$
(3.5)

Then we look at  $I_C - V_{BE}$  curve to find the region where logarithm scale  $I_C$  is linearly propotional to  $V_{BE}$ , as shown in Figure 3.1.



Figure 3.1: Measured  $I_C - V_{BE}$  curve

The figure shows that it is suitable to use the collector current between  $V_{BE} = 0.5V$  to  $V_{BE} = 0.8V$  to estimate  $I_S$ . Next we look at the measurement data and find a point in this

MULT	Numbers of transistors measured in parallel
$H_{em}$	Emitter width (dimension on silicon)
$L_{em}$	Emitter strip length (dimension on silicon)
$ ho_p$	Pinched sheet resistance of the base
$N_{base}$	Number of base stripes
$N_{epi}$	Collector epilayer doping level
$W_{epi}$	Collector epilayer thickness

Table 3.3: The layout and process quantities

region, here we use the 185th point whose  $V_{BE} = 0.67V$ , and then write a program in IC-CAP to calculate  $I_S$ . The program is listed below:

Vt = (TEMP + 273.15) \* 0.86171E-4

I = ic

V=vb-ve

Index = 185

IS=I [ Index ] // exp (V[ Index ]// Vt )

Other saturation currents  $I_{BI}$ ,  $I_{Ss}$  and  $I_{BX}$  are estimated in the same way.

3.3 Parameters that need to be calculated

The last group is the parameters whose initial value need to be calculated from layout and technology data. All parameters of this kind are initialized in this section whatever it's used or not. The layout and process quantities are given in Table 3.3 [11].

The following constants are also needed for the calculation.

Boltzmann constant is:

$$k = 1.38064852 \times 10^{-23} \,\mathrm{J/K}.$$
(3.6)

The elementary charge is:

$$q = 1.6021918 \times 10^{-19} \,\mathrm{C}.\tag{3.7}$$

Dielectric constant is:

$$\varepsilon = 1.036 \times 10^{-10} \,\mathrm{C/Vm}.$$
 (3.8)

The saturated drift velocity is:

$$v_{sat} = 8.0 \cdot 10^4 \,\mathrm{m/s.}$$
 (3.9)

The quantities calculated from the reference temperature are [11]:

$$V_T = \frac{kT_{ref}}{q},\tag{3.10}$$

$$n_i^2 = (9.61 \cdot 10^{32} \text{cm}^{-6} \text{K}^{-3}) \times \text{T}_{\text{ref}}^3 \text{e}^{-\text{V}_{\text{g}_{\text{C}}}/\text{V}_{\text{T}}}.$$
(3.11)

Process quanties are :

$$H_{em} = 0.5 \mu \mathrm{m},$$
 (3.12)

$$L_{em} = 2.5 \mu \text{m.}$$
 (3.13)

Base doping is:

$$N_{base} = 1 \times 10^{18} \text{cm}^{-3}.$$
 (3.14)

Epilayer doping is:

$$N_{epi} = 3 \times 10^{17} \text{cm}^{-3}.$$
 (3.15)

Thus the emitter surface  $(A_{em})$  and periphery  $(P_{em})$  are calculated as:

$$A_{em} = H_{em} \cdot L_{em}, \tag{3.16}$$

$$P_{em} = 2(H_{em} + L_{em}). ag{3.17}$$

The fraction of the BE depletion capacitance  $XC_{jE}$  and the fraction of the BC depletion capacitance  $XC_{jC}$  are then calculated from the layout and directly estimated data as [11]:

$$XC_{jE} = \frac{P_{em}}{P_{em} + 6A_{em}/\mu m},$$
 (3.18)

$$XC_{jC} = XC_{jE} \frac{V_{er}}{V_{ef}} \frac{C_{jE}}{C_{jC}}.$$
(3.19)

Here  $C_{jE}$  is zero-bias emitter-base depletion capacitance;  $C_{jC}$  is zero-bias collector-base capacitance;  $V_{er}$  is reverse early voltage;  $V_{ef}$  is forward early voltage.

The zero bias value of the variable part of base resistance  $R_{Bv}$ , the constant part of the base resistance  $R_{Bc}$  and the constant part of collector resistance  $R_{Cc}$  are calculated by equations [11]:

$$R_{Bv} = \frac{H_{em}\rho_p}{3N_{base}^2 L_{em}},\tag{3.20}$$

$$R_{Bc} = R_{Cc} = \frac{300\Omega \cdot \mu \mathrm{m}}{L_{em}}.$$
(3.21)

The initial values of the knee current  $I_K$  and the knee current for Base-Collector-Substrate(BCS) transistor main current  $I_{kS}$  are [11]:

$$I_K = \frac{V_{er}(1 - XC_{je})C_{je}}{\tau_B},$$
(3.22)

$$I_{kS} = (500\mu \text{A}/\mu\text{m}^2) \times \text{A}_{\text{em}} \cdot \frac{\text{I}_{\text{Ss}}}{\text{I}_{\text{S}}}.$$
(3.23)

The saturation current of the non-ideal reverse base current  $I_{Br}$  and saturation current of the non-ideal forward base current  $I_{Bf}$  are given by [11]:

$$I_{Br} = 100I_S,$$
 (3.24)

$$I_{Bf} = 100I_S. (3.25)$$

The avalanche parameters  $W_{\rm epi}$  and  $V_{\rm avl}$  are from calculation [11]:

$$W_{avl} = W_{epi}, \tag{3.26}$$

$$V_{avl} = \frac{q N_{epi} W_{epi}^2}{2\varepsilon}.$$
(3.27)

We also need spreading parameter  $\alpha_l$  and  $\alpha_h$  for the calculation of epilayer [11]. The quantities are process and geometry dependent.

$$\tan \alpha_{\rm l} = 0.5, \tag{3.28}$$

$$\tan \alpha_{\rm h} = 1.0, \tag{3.29}$$

$$S_{Fl} = \tan \alpha_{\rm l} W_{\rm epi} \left(\frac{1}{\mathrm{H}_{\rm em}} + \frac{1}{\mathrm{L}_{\rm em}}\right), \tag{3.30}$$

$$S_{Fh} = \frac{2}{3} \tan \alpha_{\rm h} W_{\rm epi} (\frac{1}{H_{\rm em}} + \frac{1}{L_{\rm em}}).$$
 (3.31)

The latter quantity is the current spreading factor for high injection, which is a parameter used in the high-current avalanche model. The epilayer parameters are calculated as below [11].

The collector-base diffusion voltage and collector-base diffusion voltage of depletion capacitance is calculated as:

$$V_{dc} = V_{d_C c t c} = V_T ln(N_{epi}^2/n_i^2).$$
(3.32)

Resistance of the un-modulated epilayer is calculated as:

$$R_{Cv} = \frac{W_{epi}}{q\mu_0 N_{epi} A_{em}} \frac{1}{(1+S_{Fl})^2}.$$
(3.33)

 $\mu_0$  is the mobility in the epilayer. Critical current for velocity saturation in the epilayer is evaluated from:

$$I_{hc} = q\mu_0 N_{epi} A_{em} v_{sat} (1 + S_{Fl})^2.$$
(3.34)

The initial value of space charge resistance of the epilayer is calculated by:

$$SCR_{Cv} = \frac{W_{epi}^2}{2\varepsilon v_{sat}A_{em}} \frac{1}{(1+S_{Fh})^2},$$
 (3.35)

 $X_p$  is the constant part of  $C_{jC}$ ,  $p_C$  is collector-base grading coefficient,  $m_C$  is coefficient for the current modulation of the collector-base depletion capacitance. These quantities are calculated by [11]:

$$xd_0 = \sqrt{\frac{2\varepsilon V_{dc}}{qN_{epi}}},\tag{3.36}$$

$$X_p = x d_0 / W_{epi}, \tag{3.37}$$

$$p_C = 0.3/(1 - X_p), \tag{3.38}$$

$$m_C = (1 - X_p)/2.$$
 (3.39)

The transit time of stored epilayer charge and transit time of reverse extrinsic stored base charge are calculated using [11]:

$$\tau_{epi} = \frac{W_{epi}^2}{4\mu_0 V_T},$$
(3.40)

$$\tau_R = \left(\tau_B + \tau_{epi} \frac{1 - XC_{jc}}{XC_{jc}}\right). \tag{3.41}$$

### 3.4 Plots after initialization

The parameters are initialized based on what we discussed in this chapter. After initialization, the important characteristics of 300 K including characteristics of Early effect and avalanche effect, forward and reverse Gummel characteristics, output curves and cut-off frequency, are shown in Figure 3.2. As we can see, although all the parameters have physical initial values, the curves of measured and the simulated values are still much different.



Figure 3.2: Plots of important characteristics at 300 K after initialization.

The forward and reverse currents in Gummel measurement at different temperatures are shown in Figure 3.3, the output characteristics and cut-off frequency curves at different temperatures are shown in Figure 3.4. The curves of their measured values and simulated values are also very different.



Figure 3.3: Currents at different temperature after initialization.



Figure 3.4: Plots of important characteristics at different temperature after initialization.

### Chapter 4

# Extraction of Low Current Parameters

As discussed earlier in 2.2, a logical starting step is to extract low current parameters, which are relatively straightforward as self-heating is negligible. Low current parameters include the parameters of depletion capacitances, avalanche effect, Early effect, and Gummel characteristics. Resistances are high current parameters but they can be estimated from high current region in Gummel plots. Temperature scaling parameters related to these parameters are also extracted here in order to provide a better description of low current parameters and a reasonable starting point for high current parameters. The reference temperature is 26.85 °C (300 K).

### 4.1 Depletion capacitance

The descriptions of capacitances contain some parameters which are essential for follow-up works, so the parameters of capacitances are extracted at the first step.

#### 4.1.1 Base-emitter depletion capacitance

The measured base-emitter capacitance  $C_{BE}$  contains three parts: a depletion capacitance, an overlap capacitance and a diffusion capacitance. The contribution of diffusion capacitance can be ignored as long as base-emitter voltage  $V_{BE}$  is not too high in forward. The base-emitter depletion capacitance  $C_{BE}$  is given by the formula [11]:

$$C_{BE} = \frac{s_E C_{jE}}{(1 - \frac{V_{jE}}{V_{dE}})^{p_E}} + \frac{(1 - s_E)C_{jE}}{(1 - \frac{V_{FE}}{V_{dE}})^{p_E}} + C_{BEO},$$
(4.1)

#	parameter	value	comment
1	CjE	12.14f	
2	PE	561.9m	
3	V <sub>dE</sub>	2.158	
4	C <sub>BEO</sub>	0	Use default value

Table 4.1: Parameters used in base-emitter depletion capacitance extraction.

this equation describes the transition between a depletion capacitance(when  $s_E = 1$ ) to a constant capacitance(when  $s_E = 0$ ).  $C_{j_E}$  is the zero-bias emitter base depletion capacitance.  $V_{d_E}$  is diffusion voltage.  $p_E$  represents emitter-base grading coefficient.

 $V_{j_E}$  is the effective junction bias which is given by:

$$V_{iE} = V_{BE} + 0.1 V_{dE} \ln s_E, \tag{4.2}$$

 $s_E$  describes the transition between the ideal and the constant part and it is given by:

$$s_E = \frac{1}{1 + e^{\frac{V_{BE} - V_{FE}}{0.1V_{dE}}}}.$$
(4.3)

The voltage  $V_{FE}$  describes the point where the transition takes place and it is defined by the quantity  $a_{j_E}$ ,

$$V_{FE} = V_{dE} (1 - a_{jE}^{-\frac{1}{PE}}), (4.4)$$

 $a_{jE}$  is a constant 3 here. The capacitance  $C_{BEO}$  is constant, which describes the overlap capacitances between base and emitter.  $C_{BEO}$  is set to zero here due to lack of geomery scaling and process information. The extracted  $C_{jE}$  is actually a sum of real  $C_{jE}$  and  $C_{BEO}$ .  $C_{jE}$ ,  $p_E$  and  $V_{dE}$  are extracted by fitting plot  $C_{BE} - V_{BE}$ . The extraction result is shown in Figure 4.1. The values of parameters extracted in this section are given in Table 4.1.

#### 4.1.2 Base-collector depletion capacitance

The extraction of the base-collector depletion capacitance and base-emitter depletion capacitance are similar. Parameter  $X_p$  is introduced here to describe the constant part of the capacitance, which indicates that the collector epilayer has a finite thickness. The base-collector



Figure 4.1: Measured (markers) and calculated (line) BE depletion capacitance at 300 K

depletion capacitance is given as [11]:

$$C_{BC} = \frac{S_C (1 - X_p) C_{jC}}{(1 - V_{jC} / V_{d_C ctc})^{p_C}} + \frac{(1 - S_C) (1 - X_p) C_{jC}}{(1 - V_{FC} / V_{d_C ctc})^{p_C}} + X_P C_{jC} + C_{BCO},$$
(4.5)

$$V_{jC} = V_{BC} + 0.1 V_{d_C ctc} \ln s_C, \tag{4.6}$$

$$s_C = \frac{1}{1 + e^{\frac{V_{BC} - V_{FC}}{0.1 V_{d_C ctc}}}},$$
(4.7)

$$b_{j_C} = \left(\frac{a_{jC} - X_P}{1 - X_P}\right),\tag{4.8}$$

$$V_{FC} = V_{d_C ctc} (1 - b_{j_C}^{-\frac{1}{p_C}}).$$
(4.9)

Here we have  $a_{jC} = 2$ . Parameter  $C_{jC}$  is zero bias collector-base depletion capacitance,  $p_C$  is collector-base grading coefficient,  $V_{d_Cctc}$  is collector-base diffusion voltage of depletion capacitance.  $C_{BCO}$  is the base-collector overlap capacitance and it is also set to zero, for the extracted  $C_{jC}$  is actually a sum of real  $C_{jC}$  and  $C_{BCO}$  for they cannot be separated here.  $V_{jC}$  is the effective junction bias. The transition between the ideal and the constant part is described by  $s_C$ . The voltage  $V_{FC}$  describes the point where the transition takes place.  $C_{jC}$ ,  $p_C$ ,  $V_{d_Cctc}$ 



Figure 4.2: Measured (markers) and calculated (line) BC depletion capacitance at 300 K

#	parameter	value	comment
1	C <sub>jc</sub>	5.452f	
2	Pc	368.9m	
3	$V_{d_{C}ctc}$	719.5m	
4	X <sub>p</sub>	210.0m	
5	C <sub>BCO</sub>	0	Use default value

Table 4.2: Parameters used in base-collector depletion capacitance extraction.

and  $X_p$  are extracted by fitting the  $C_{BC} - V_{BC}$  curve as shown in Figure 4.2. The values of parameters extracted in this section are given in Table 4.2.

# 4.1.3 Collector-substrate depletion capacitance

The extraction of collector-substrate capacitance is also similar to  $C_{BE}$ . The equations of collector-substrate depletion capacitance are :

$$C_{SC} = \frac{s_S C_{jS}}{(1 - \frac{V_{jS}}{V_{dS}})^{p_S}} + \frac{(1 - s_S) C_{jS}}{(1 - \frac{V_{FS}}{V_{dS}})^{p_S}},$$
(4.10)

$$V_{jS} = V_{SC} + 0.1 V_{dS} \ln s_S, \tag{4.11}$$

$$s_S = \frac{1}{1 + e^{\frac{V_{SC} - V_{FS}}{0.1V_{dS}}}},\tag{4.12}$$



Figure 4.3: Measured (markers) and calculated (line) SC depletion capacitance at 300 K

$$V_{FS} = V_{dS} (1 - a_{jS}^{-\frac{1}{PS}}).$$
(4.13)

 $V_{j_S}$  is the effective junction bias.  $s_S$  describes the transition between the ideal and the constant part. The voltage  $V_{FS}$  is used to describe the point where the transition takes place and it's defined by  $a_{jS}$  whose value is 2.  $C_{jS}$  is zero bias collector-substrate depletion capacitance.  $p_S$ is collector-substrate grading coefficient.  $V_{dS}$  is collector-substrate diffusion voltage.  $C_{jS}$ ,  $V_{dS}$ and  $p_S$  can be extracted by fitting  $C_{SC} - V_{SC}$  curve. Figure 4.3 shows the extracted result. The values of parameters extracted in this section are given in Table 4.3.

#	parameter	value	comment
1	C <sub>js</sub>	9.598f	
2	р <sub>S</sub>	119.1m	
3	$V_{d_S}$	509.1m	

Table 4.3: Parameters used in collector-substrate depletion capacitance extraction.

#### 4.2 Avalanche

Modern transistors have lower breakdown voltage, making the avalanche effect of a transistor more of a concern. The avalanche current  $I_{avl}$ , which is caused by impact ionization, could cause a decrease of base current when the collector-base bias is sufficiently high.

### 4.2.1 Extraction of avalanche parameters at 300 K

The low current avalanche parameters are extracted from base current under forward Early measurement shown in Figure 4.4,  $V_{BE}$  is set to 0.68V,  $V_{CB}$  is swept from 0 to 5.0V.



Figure 4.4: Simplified forward Early measurement circuit

In Mextram 505.00, switch parameter SWAVL for avalanche factor is added. When SWAVL = 0, there is no avalanche current. SWAVL = 1 is the default value and the new

avalanche model is used at this time. When SWAVL is 2, Mextram 504 avalanche model is used. EXAVL is only meaningful when SWAVL is 2. In this work, SWAVL is the default value 1.

Since avalanche current leads to the decrease of base current when  $V_{CB}$  increases, it could be expressed as the difference between the base current at  $V_{CB} = 0$  and at higher  $V_{CB}$ . The avalanche current is written as:

$$I_{avl} = I_{B0} - I_B. (4.14)$$

 $I_{B0}$  is the base current at  $V_{CB} = 0$ . As  $V_{CB}$  increasing, the base current may drop below zero because avalanche effect occurs. The avalanche current can also be expressed as:

$$I_{avl} = I_N G_{EM}, \tag{4.15}$$

 $G_{EM}$  is the generation coefficient, which is given by equation in Mextram 505.00 as:

$$G_{EM} = \frac{A_{avl}}{B_{avl}} \phi \exp(-B_{avl} \phi^{C_{avl}}), \qquad (4.16)$$

$$\phi = (V_{d_Cavl} + V_{CB}) \exp(-\frac{I_N}{I_{TOavl}}), \qquad (4.17)$$

 $A_{avl}$ ,  $B_{avl}$ ,  $C_{avl}$ ,  $V_{d_Cavl}$ , and  $I_{TOavl}$  are avalanche parameters for this model. From equation (4.15),  $G_{EM}$  can also be expressed as:

$$G_{EM} = \frac{I_{avl}}{I_N},\tag{4.18}$$

As shown in Figure 4.4,  $I_C = I_{avl} + I_N$ .  $G_{EM}$  can be rewritten as:

$$G_{EM} = \frac{I_{avl}}{I_C - I_{avl}}.$$
(4.19)

As  $I_{avl}$  is already obtained from  $I_B$ ,  $G_{EM}$  can now be calculated from measured  $I_C$  and  $I_B$ .

Using (4.19), a transform for calculating  $G_{EM}$  is written in IC-CAP. The program code is listed below:

```
Ib0m=ib.m[0]
Ib0s=ib.s[0]
iav1=ib
i=0
while i < size(vc)
iav1.m[i]=Ib0m-ib.m[i]
iav1.s[i]=Ib0s-ib.s[i]
i=i+1
end while

gem=ic

q=0

while q < size(vc)
gem.m[q]=iav1.m[q] //(ic.m[q]-iavl.m[q])
gem.s[q]=iav1.s[q] //(ic.s[q]-iavl.s[q])
q=q+1
```

## end while

```
return gem + 1e-6
```

 $A_{avl}$ ,  $B_{avl}$ ,  $C_{avl}$ , and  $V_{d_Cavl}$  are extracted here by fitting  $G_{EM}$ - $V_{cb}$  curve.  $I_{TOavl}$  cannot be extracted here, but we need to set its value large enough compared to the collector current in question so that it does not affect low current avalanche parameters. That is, the exponential term in (4.17) needs to be essentially unity.  $I_{TOavl}$  describes the decrease of  $G_{EM}$  with increasing  $I_C$  at high current, and will be extracted later in a region of high  $I_C$  from output curves.

 $G_{EM}$  versus  $V_{CB}$  are shown in Figure 4.5 in both linear and logarithmic scales for  $G_{EM}$ . The values of avalanche parameters used in this step are given in Table 4.4.

#	parameter	value	comment
1	A <sub>avl</sub>	237.3	
2	B <sub>avl</sub>	14.51	
3	C <sub>avl</sub>	-528.1m	
4	$V_{d_{C}avl}$	192.2m	
5	I <sub>TOavl</sub>	500m	To be extracted from output plots

Table 4.4: Parameters used in avalanche factor extraction.



Figure 4.5: Linear scale and log scale  $G_{EM}$  versus  $V_{CB}$  at 300 K

#	parameter	value	comment
1	T <sub>Bavl</sub>	$473.9\mu$	

Table 4.5: Temperature scaling parameter of avalanche factor.

# 4.2.2 Temperature scaling of avalanche effect

 $B_{avl}$  has temperature dependence given by:

$$B_{avl_T} = B_{avl}(1 + T_{Bavl}(T_K - T_{ref})), (4.20)$$

where  $T_{Bavl}$  is temperature scaling parameter. By fitting  $G_{EM}$ - $V_{cb}$  curve under differet temperatures at 223 K, 300 K and 393 K,  $T_{Bavl}$  is extracted. The extraction results are shown in Figure 4.6. The parameter extracted here is shown in Table 4.5.



Figure 4.6: Linear scale and log scale  $G_{EM} - V_{CB}$  at different temperatures

#### 4.3 Early Effect

Early effect is the variation in the base width of a BJT due to the applied base-collector and base-emitter bias variation. In Mextram we have two parameters, reverse Early voltage  $V_{er}$  and forward Early voltage  $V_{ef}$ , to describe this bias-dependet effect.  $V_{er}$  is extracted from reverse Early measurement and  $V_{ef}$  is extracted from forward Early measurement. In SiGe transistors Ge mole fraction has a non-zero slope, which means we have a non-zero base bandgap difference  $dE_g$ . Thus, Mextram redefines the coefficient  $q_1^I$  to describe Early effect for the currents [8] as:

$$q_1^I = \frac{\exp(\left[\frac{V_{tE}}{V_{er}} + 1\right]\frac{dE_g}{V_T}) - \exp(\frac{-V_{tC}}{V_{ef}}\frac{dE_g}{V_T})}{\exp(\frac{dE_g}{V_T}) - 1}.$$
(4.21)

Neglecting the voltage drop over resistances, the normalized charges  $V_{tE}$  and  $V_{tC}$  are evaluated from:

$$V_{tE} = \frac{V_{dE}}{1 - p_E} [1 - (1 - V_{jE}/V_{dE})^{1 - p_E}] + a_{jE}(V_{BE} - V_{jE}), \qquad (4.22)$$

$$V_{tC} = (1 - X_p) \left( \frac{V_{dC}}{1 - p_C} \left[ 1 - (1 - V_{jC}/V_{dC})^{1 - p_C} \right] + b_{jC} (V_{BC} - V_{jC}) \right) + X_p V_{BC}.$$
 (4.23)

 $V_{tE}$  and  $V_{tC}$  are calculated using parameters extracted in C - V characteristics. The emitter current for the reverse Early effect measurement setup is written as:

$$I_E = I_{E0} \frac{\exp(\frac{dE_g}{V_T}) - \exp(\frac{-V_{tC}}{V_{ef}}\frac{dE_g}{V_T})}{\exp([\frac{V_{tE}}{V_{er}} + 1]\frac{dE_g}{V_T}) - \exp(\frac{-V_{tC}}{V_{ef}}\frac{dE_g}{V_T})}.$$
(4.24)

 $I_{E0}$  is the emitter current at  $V_{BE} = 0$ . The collector current for the forward Early effect measurement setup can be written as:

$$I_{C} = I_{C0} \frac{\exp([\frac{V_{tE}}{V_{er}} + 1]\frac{dE_{g}}{V_{T}})}{\exp([\frac{V_{tE}}{V_{er}} + 1]\frac{dE_{g}}{V_{T}}) - \exp(\frac{-V_{tC}}{V_{ef}}\frac{dE_{g}}{V_{T}})} + I_{B0} - I_{B},$$
(4.25)

where  $I_{C0}$  is the collector current at  $V_{BC} = 0$ ,  $I_{B0}$  is the base current at  $V_{CB} = 0$ . It is clear from inspection of these equations that the emitter current depends on forward Early voltage, reverse Early voltage and bandgap difference  $dE_g$ , and the collector current also depends on both voltages and bandgap difference. Therefore, we extract them at the same time.

The fractions containing  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  in above expressions are current change factors due to Early effect. In our extraction, rather than fitting currents, we fit these current change factors calculated using:

$$F_{revEarly} = \frac{I_E}{I_{E0}},\tag{4.26}$$

$$F_{fwdEarly} = \frac{I_C - I_{avl}}{I_{C0}},\tag{4.27}$$

where  $I_{avl}$  is avalanche current defined in (4.14).  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  are extracted by fitting  $F_{revEarly}$  and  $F_{fwdEarly}$  together.  $F_{revEarly} - V_{EB}$  and  $F_{fwdEarly} - V_{CB}$  are shown in Figure 4.7.



Figure 4.7:  $F_{revEarly} - V_{EB}$  and  $F_{fwdEarly} - V_{CB}$  at 300 K

From equation (4.25) we can see that  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  have the ability of influencing  $I_C$ and therefore influence the current gain. Thus, these parameters should be optimized later in current gain plot. The values of  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  extracted from this step are listed in Table 4.6.

#	parameter	value	comment
1	$V_{er}$	3.146	To be optimized in current gain plot
2	$V_{ef}$	47.35	To be optimized in current gain plot
3	$dE_g$	25.59m	To be optimized in current gain plot

Table 4.6: Parameters used in Early effect extraction.

### 4.4 DC Gummel parameters

We now proceed with extracting forward and reverse Gummel related model parameters as well as related temperature scaling parameters.

#### 4.4.1 Extraction of forward Gummel parameters

The collector saturation current  $I_S$ , a crucial parameter describing the main current, is extracted at medium-low base-emitter voltages, to avoid high-injection, quasi-saturation, series resistance effects, as well to avoid non-ideal leakage currents. At such bias,  $I_C$  is approximately given by:

$$I_{C} = \frac{I_{S} \exp \frac{V_{BE}}{N_{FF}V_{T}}}{q_{1}^{I}},$$
(4.28)

where  $q_1^I$ , the current change factor due to Early effect, is given by (4.21). Its value has to do with the C-V parameters and Early effect parameters, which have been extracted. In future extraction steps, any adjustment to those parameters will require adjustment of  $I_S$  as well.  $N_{FF}$ is the non-ideality factor of forward main current. In this work,  $N_{FF}$  is set to its default value 1, which is found to be sufficient. The extraction result is shown in Figure 4.8.

Figure 4.8 shows that at medium  $V_{BE}$ , logarithm scale  $I_C$  is approximately a linear function of the base-emitter bias as the equation (4.28) described. However, when the bias becomes larger, the measured  $I_C$  and simulated  $I_C$  split. This is in part due to the series resistance voltage drops. The intrinsic junction voltage  $V_{B_2E_1}$  becomes considerably smaller than the bias we apply,  $V_{BE}$ . We can minimize this difference later by extracting reasonable resistances in section 4.4.3. Here we only focus on the medium  $V_{BE}$  range from 0.5V to 0.8V, to extract  $I_S$ . The values of parameter used here are shown in Table 4.7.



Figure 4.8: Measured (markers) and simulated (line) collector current in forward Gummel measurement at 300 K

#	parameter	value	comment
1	ls	2.699a	
2	N <sub>FF</sub>	1.0	Use default value

Table 4.7: Parameters used in forward  $I_C$  in Gummel measurement.

The parameters of forward base current are also extracted in forward Gummel measurement. Ideal base current is evaluated by:

$$I_{B_1} = I_{BI}(e^{V_{B_2 E_1}/N_{BI}V_T} - 1).$$
(4.29)

Ideal side-wall base current is written as:

$$I_{B_1}^S = I_{BI}^S (e^{V_{B_1 E_1} / N_{BI}^S V_T} - 1).$$
(4.30)

Non-ideal base current is:

$$I_{B_2} = I_{Bf} (e^{V_{B_2 E_1}/m_{Lf} V_T} - 1).$$
(4.31)

Non-ideal side-wall base current is:

$$I_{B_2}^S = I_{B_f}^S (e^{V_{B_2 E_1}/m_{L_f}^S V_T} - 1).$$
(4.32)

 $I_{BI}$  is the saturation current of ideal base current,  $N_{BI}$  is the non-ideality factor of ideal base current and it keeps its default value here.  $I_{BI}^S$  is the saturation current of ideal side-wall base current and  $N_{BI}^S$  is the non-ideality factor of ideal side-wall base current. Saturation current of non-ideal forward base current is represented by  $I_{Bf}$  and the non-ideality factor of non-ideal forward base current is  $m_{Lf}$ .  $I_{Bf}^S$  and  $m_{Lf}^S$  are saturation current and the non-ideality factor of non-ideal side-wall forward base current. The total base current  $I_B$  is the sum of currents in equation (4.29) - (4.32). Actually, the parameters of  $I_{B1}^S$  and  $I_{B2}^S$  are not extracted, since we just have one transistor so it is not possible to have any information of side-wall currents. The extraction result is shown in Figure 4.9.



Figure 4.9: Measured (markers) and simulated (line) base current in forward Gummel measurement at 300 K

Similar to the extraction of  $I_S$ , we extract forward base current parameters at medium-low bias in order to avoid the region where high current effects and resistance effect may occur. The values of parameter used here are shown in Table 4.8.

### 4.4.2 Extraction of reverse Gummel parameters

First, we extract the parameters of  $I_{sub}$ , which is the main current of the parasitic Base-Collector-Substrate(BCS) transistor. In this work EXSUB = 1, so the substrate current is given by:

#	parameter	value	comment
1	I <sub>BI</sub>	1.325E-20	
2	N <sub>BI</sub>	1.0	Use default value
3	I <sup>S</sup> BI	0.0	Use default value
4	N <sup>S</sup> BI	1.0	Use default value
5	I <sub>Bf</sub>	562.8a	
6	m <sub>Lf</sub>	2.741	
7	I <sup>S</sup> <sub>Bf</sub>	0.0	Use default value
8	$m^{S}_{Lf}$	2.0	Use default value

Table 4.8: Parameters used in forward  $I_B$  in Gummel measurement.

$$I_{sub} = (1 - X_{ext}) \frac{2I_{Ss}(e^{V_{B_1}C_4/V_T} - e^{V_{SC_4}/V_T})}{1 + \sqrt{1 + 4\frac{I_{Ss}}{I_{Ks}}e^{V_{B_1}C_4/V_T}}},$$
(4.33)

 $I_{Ss}$  is the saturation current of parasitic BCS transistor main current.  $I_{Ks}$  is the knee current of this parasitic transistor's collector-substrate junction.  $X_{ext}$  is the partitioning factor of the extrinsic region.

The substrate-collector diode current is calculated by:

$$I_{sf} = I_{CSs}(e^{V_{SC_1}/V_T} - 1), (4.34)$$

 $I_{CSs}$  is the ideal saturation current of collector-substrate junction. We also extract the parameters of reverse  $I_B$  in this measurement. The reverse  $I_B$  contains an ideal part and a non-ideal part. Ideal reverse base current is:

$$I_{ex} = (1 - X_{ext}) \frac{2I_{BX}(e^{V_{B_1C_4}/V_T} - 1)}{1 + \sqrt{1 + 4\frac{I_{BX}}{I_{kBX}}}e^{V_{B_1C_4}/V_T}}.$$
(4.35)

Non-ideal reverse base current is generated from the depleted base-collector region by recombination and it is expressed by equation:

$$I_{B_3} = I_{Br} (e^{V_{B_1 C_4}/m_{Lr} V_T} - 1), (4.36)$$

 $I_{BX}$  is the saturation current of ideal reverse base current  $I_{ex}$ .  $I_{kBX}$  is the knee current of  $I_{ex}$ .  $I_{Br}$  is the saturation current of non-ideal reverse base current.  $m_{Lr}$  is the non-ideality factor of  $I_{B_3}$ .

Reverse  $I_{sub}$  and  $I_B$  have strong correlation so their parameters are extracted by fitting  $I_{sub}$ ,  $I_{ex}$  and  $I_{B_3}$  together . Again, we only focus on the extraction of low  $V_{BC}$  region so that we could neglect those undesired effects.  $X_{ext}$  is the fraction of external charges and currents between B and  $C_1$  instead of  $B_1$  and  $C_1$ . From Figure 1.5 we can know that over the resistance  $R_{BC}$  the reverse base currents are split in a part with  $X_{ext}$  and a part with  $(1 - X_{ext})$ , therefore  $X_{ext}$  and  $R_{BC}$  should be extracted together from high  $V_{BC}$  where the reverse currents are high. Here  $X_{ext}$  uses its initialized value. The values of parameter used are shown in Table 4.9. Due to the voltage drop over resistances, the simulated currents and the measured currents split at high  $V_{BC}$ .



Figure 4.10:  $I_{sub} - V_{BC}$  and  $I_B - V_{BC}$  in reverse Gummel measurement at 300 K

#	parameter	value	comment
1	l <sub>Ss</sub>	3.449E-21	
2	I <sub>Ks</sub>	21.28u	
3	X <sub>ext</sub>	630m	Extracted at high $V_{BC}$ together with $R_{BC}$
4	I <sub>CSs</sub>	3.202p	
5	I <sub>BX</sub>	1.633E-19	
6	I <sub>kBX</sub>	155.4u	
7	I <sub>Br</sub>	562.8a	
8	m <sub>Lr</sub>	2.851	

Table 4.9: Parameters used in reverse Gummel measurement.

#	parameter	value	comment
1	R <sub>E</sub>	11.39	Optimized in high current output plot
2	R <sub>BC</sub>	16.47	
3	R <sub>BV</sub>	20.34	
4	R <sub>cc</sub>	9.729	Optimized in high current output plot
5	R <sub>cv</sub>	25.96	Optimized in high current output plots
6	X <sub>ext</sub>	585.2m	

Table 4.10: Resistances estimated in Gummel measurement.

## 4.4.3 Estimation of resistances

From former extractions of Gummel plots we know that the simulated data and the measured data cannot fit well, one of the reasons is that resistances have influence on the currents especially when the bias is high, so a good estimation of resistances is very important.

First we look at  $R_E$ ,  $R_{BC}$ ,  $R_{BV}$ ,  $R_{CC}$  and  $R_{CV}$ , which have a large influence on high bias Gummel characteristics.  $R_E$  is the emitter resistance between node E and E1.  $R_{BC}$ and  $R_{BV}$  are the constant part and the variable part of base resistance.  $R_{CC}$  is the constant collector resistance. For low base-collector bias,  $R_{CV}$  determines the ohmic voltage drop over the epilayer. Forward currents  $I_C$  and  $I_B$  are strongly affected by  $R_E$ , and also influenced by  $R_{BC}$  and  $R_{BV}$ .  $R_{CC}$  has large impact on reverse currents  $I_{sub}$  and  $I_B$ , and its influence on forward  $I_C$  is not negligible.  $R_{CV}$  mainly influences forward  $I_C$  and reverse  $I_{sub}$ . Moreover, the partitioning factor of the extrinsic region  $X_{ext}$ , is extracted from high reverse currents.

Therefore,  $R_E$ ,  $R_{BC}$ ,  $R_{BV}$ ,  $R_{CC}$ ,  $R_{CV}$  and  $X_{ext}$  are extracted by fitting forward currents and reverse currents together. Figure 4.11 shows  $I_C - V_{BE}$ ,  $I_B - V_{BE}$ ,  $I_{sub} - V_{BC}$  and  $I_B - V_{BC}$ after parameter extraction. Values of parameter used here are shown in Table 4.10.


Figure 4.11: Forward  $I_C$  and  $I_B$  and reverse  $I_{sub}$  and  $I_B$  in Gummel measurement at 300 K

It is obvious that after the extraction of resistances the currents at higher bias fit much better than before. Actually, when the bias and currents become larger, the effect of self-heating also needs to be taken into consideration, so the temperature scaling of these curves are done later in section 4.4.4.

# 4.4.4 Temperature scaling of Gummel parameters

The junction temperature  $T_K$  in the forward and reverse Gummel measurement at 300 K are shown in Figure 4.12 and Figure 4.13.

As we can see,  $T_K$  increases as the bias gets higher. In forward Gummel measurement the value of  $T_K$  increases from 300 K to around 313 K, and in reverse mode it ends up around 307 K. This allows us to get an more intuitive aware that we cannot neglect the temperature scaling at high bias. Therefore, the temperature scaling parameters related to Gummel characteristics are extracted here.



Figure 4.12:  $T_K$  of forward Gummel measurement at 300 K

Temperature scaling of low injection forward Gummel  $I_C$  is primarily determined by the temperature scaling of the collector current saturation current:

$$I_{sT} = I_s t_N^{\frac{4-A_B - A_{Q_{B0}} + DAIS}{N_{FF}}} \exp[-\frac{V_{gB}}{N_{FF}V_{\Delta T}}].$$
(4.37)

 $N_{FF}$  is also linearly scaled with temperature, with a coefficient  $t_{NFF}$  that defaults to zero, which we use here. That is,  $N_{FFT} = N_{FF}$ . The same  $A_B$  parameter is also used for temperature scaling of the knee current  $I_k$ , which is important for high injection Gummel  $I_C$ :

$$I_{kT} = I_k t_N^{1-A_B}.$$
 (4.38)

Low injection temperature scaling of forward ideal  $I_B$  comes from temperature dependence of  $I_{BI}$ :

$$I_{BIT} = I_{BI} t_N^{\frac{4-A_E + DAIS}{N_{BI}}} \exp[-\frac{V_{gE}}{N_{BI}V_{\Delta T}}].$$
(4.39)

Similarly, temperature scaled forward side-wall ideal  $I_B$  saturation current is given by:

$$I_{BIT}^{S} = I_{BI}^{S} t_{N}^{\frac{4-A_{E}+DAIS}{N_{BI}^{S}}} \exp[-\frac{V_{gE}}{N_{BI}^{S} V_{\Delta T}}].$$
(4.40)



Figure 4.13:  $T_K$  of reverse Gummel measurement at 300 K

Temperature scaled forward non-ideal  $I_B$  saturation current is given by:

$$I_{BFT} = I_{BF} t_N^{6-2m_{Lf}} \exp[-\frac{V_{gJ}}{m_{Lf} V_{\Delta T}}].$$
(4.41)

Temperature scaled forward non-ideal side-wall  $I_B$  saturation current is given by:

$$I_{BFT}^{S} = I_{BF}^{S} t_{N}^{6-2m_{Lf}^{S}} \exp[-\frac{V_{gJ}}{m_{Lf}^{S} V_{\Delta T}}].$$
(4.42)

As we discussed in section 4.4.1,  $I_{BI}^S$  and  $I_{BF}^S$  are using the default value 0, so they are not used to extract temperature parameters.

The temperature scaled saturation currents relevant for reverse Gummel  $I_B$ , strictly speaking,  $I_B + I_{sub}$ , are:

$$I_{BXT} = I_{BX} t_N^{4-A_{CX}+DAIS} \exp\left[-\frac{V_{gCX}}{V_{\Delta T}}\right],\tag{4.43}$$

$$I_{kBXT} = I_{kBX} t_N^{1-A_{CX}}, (4.44)$$

$$I_{BrT} = I_{Br} t_N^{6-2m_{Lr}} \exp[-\frac{V_{gC}}{m_{Lr} V_{\Delta T}}].$$
(4.45)

The temperature dependence of substrate current  $I_{sub}$  is given by:

$$I_{SsT} = I_{Ss} t_N^{4-A_S} \exp[-\frac{V_{gS}}{V_{\Delta T}}],$$
(4.46)

$$I_{CS_sT} = I_{CS_s} t_N^{3.5-0.5A_{sub}} \exp[-\frac{V_{gS}}{V_{\Delta T}}],$$
(4.47)

$$I_{ksT} = I_{ks} t_N^{1-A_S}.$$
 (4.48)

The parameters describing the temperature dependence of resistances are also extracted in Gummel plots to provide a reasonable basis for the extraction of output curves. The scaled resistances are given by:

$$R_{ET} = R_E t_N^{A_E},\tag{4.49}$$

$$R_{BVT} = R_{BV} t_N^{A_B - AQ_{B0}}, (4.50)$$

$$R_{BCT} = R_{BC} t_N^{A_{EX}}, aga{4.51}$$

$$R_{CCT} = R_{CC} t_N^{A_C}, aga{4.52}$$

$$R_{CVT} = R_{CV} t_N^{A_{epi}}. (4.53)$$

Table 4.11 summerizes temperaure scaling parameters of Gummel characteristics. Parameters  $V_{gE}$ ,  $V_{gB}$ ,  $V_{gJ}$  can be extracted by fitting forward  $I_B$  and  $I_C$  together for DAIS is used in both currents.  $A_B$  is not extracted here for the influence of  $I_K$  is not so significant here that it will be extracted later in DC output curves. Here we use the initialized value of  $A_B$  to estimated DAIS,  $V_{gB}$  and  $A_{QBO}$ , these parameters are going to be optimized when we extract  $A_B$ .

 $V_{gS}$ ,  $V_{gC}$ ,  $V_{gCX}$ ,  $A_S$ ,  $A_{sub}$  and  $A_{CX}$  are extracted by fitting reverse  $I_{sub}$  and  $I_B$  together. Temperature scaling parameters describing resistances and DAIS need to be extracted by fitting all Gummel plots together for they have the influence on both forward and reverse currents. Therefore, the parameters of forward and reverse Gummel characteristics are extracted together by fitting I - V curves at 223 K, 300 K and 393 K together. When we are fitting these curves, it appears that the leakage current of substrate current is too large so  $I_{CS_sT}$  is adjusted along with its temperature coefficient  $A_{sub}$ .  $m_{Lr}$  is also adjusted since the non-ideal current  $I_{B3}$  is not

forward Gummel	I <sub>sT</sub>	1. $A_B + A_{Q_{B0}} - DAIS$
		2. V <sub>gB</sub>
	I <sub>kT</sub>	A <sub>B</sub>
	I <sub>BIT</sub>	1. A <sub>E</sub> – DAIS
		2. V <sub>gE</sub>
	I <sub>BFT</sub>	V <sub>g</sub> J
reverse Gummel	I <sub>BXT</sub>	1. $A_{CX} - DAIS$
		2. V <sub>gCX</sub>
	I <sub>kBXT</sub>	A <sub>CX</sub>
	I <sub>BrT</sub>	V <sub>gC</sub>
	I <sub>SsT</sub>	1. A <sub>S</sub>
		2. V <sub>gS</sub>
	I <sub>CS₅T</sub>	1. A <sub>sub</sub>
		2. V <sub>gS</sub>
	I <sub>ksT</sub>	As
resistance	R <sub>E</sub>	A <sub>E</sub>
	R <sub>BC</sub>	A <sub>EX</sub>
	R <sub>BV</sub>	$A_{B} - AQ_{B0}$
	R <sub>cc</sub>	A <sub>C</sub>
	R <sub>cv</sub>	A <sub>epi</sub>

Table 4.11: Temperaure scaling parameters of Gummel characteristics.

good. The I - V curves before temperature scaling and optimizing  $I_{CS_sT}$  and  $m_{Lr}$  are shown in Figure 4.14, the optimized curves are shown in Figure 4.15. Values of parameters used here are shown in Table 4.12.



Figure 4.14: I - V curves of Gummel measurement before temperature scaling and optimizing  $I_{CS_sT}$  and  $m_{Lr}$ .



Figure 4.15: I - V curves of Gummel measurement after temperature scaling and optimizing  $I_{CS_sT}$  and  $m_{Lr}$ , generated by parameters in Table 4.12.

#	parameter	value	comment
1	A <sub>B</sub>	1	Extracted in high current output plot
2	$A_{Q_{B0}}$	356.9m	Need to be optimized with $A_B$
3	DAIS	12.94m	Optimized in high current output plot
4	$V_{gB}$	1.169	
5	A <sub>E</sub>	-35.31m	Optimized in high current output plot
6	$V_{gE}$	1.114	
7	V <sub>g</sub> J	1.611	
8	A <sub>CX</sub>	1.268	
9	$V_{gCX}$	1.124	
10	V <sub>gC</sub>	1.23	
11	As	1.66	
12	$V_{gS}$	1.199	
13	A <sub>sub</sub>	1.967	
14	Ac	1.951	Optimized in high current output plot
15	A <sub>EX</sub>	366.8m	Optimized in high current output plot
16	A <sub>epi</sub>	2.745	Optimized in high current output plot
17	I <sub>CSs</sub>	89.26a	
18	m <sub>Lr</sub>	2.741	

Table 4.12: Parameters used in temperature scaling parameter extraction of Gummel characteristics, used to gerenate Figure 4.15.

## 4.4.5 Estimation of $V_{dC}$

With good extraction results of the parameters used to calculate currents, the current gain is supposed to be described well. The forward current gain  $h_{fe}$  is calculated from  $I_B$  and  $I_C$  in forward Gummel measurement:

$$h_{fe} = \frac{I_C}{I_B},\tag{4.54}$$

 $h_{fe}$  is shown in Figure 4.16. The simulated and measured  $h_{fe}$  does not fit so well. We can



Figure 4.16: Measured (markers) and simulated (line) forward current gain  $h_{fe}$ 

optimize  $V_{er}$ ,  $V_{ef}$ ,  $I_S$  and  $dE_g$  to get a better description of currents. Compared to  $V_{er}$ , we care more about  $V_{ef}$  for most of time transistors work in forward mode. Therefore we optimize  $V_{er}$ ,  $V_{ef}$ ,  $I_S$  and  $dE_g$  by fitting  $h_{fe}$  and  $F_{fwdEarly}$  together.

When bias gets higher, the current gain starts to fall. Diffusion voltage  $V_{dC}$  is one of the parameters contributing to the decrease of the current gain. As we discussed before, the collector resistance  $R_{CC}$  and  $R_{CV}$  can lead to a voltage drop between the external collector and the internal collector. When this voltage drop is sufficiently high, the internal junction bias  $V_{B_2C_2}$  can be comparable to the value of  $V_{dC}$  and this internal base-collector junction is therefore forward biased. Then it is time to speak of quasi-saturation. Thus, the diffusion voltage  $V_{dC}$  is extracted in the region where the forward current gain is falling.  $V_{dC}$  also needs to

#	parameter	value	comment
1	V <sub>er</sub>	2.775	
2	V <sub>ef</sub>	46.82	
3	dEg	21.82m	
4	V <sub>dc</sub>	897.3m	Optimized the cut-off frequency plot
5	Is	2.618m	

Table 4.13: Parameters used in fitting  $h_{fe}$ , used to generate Figure 4.17.

be optimized later when we extract cut-off frequency, for cut-off frequency strongly depends on the current gain. Figure 4.17 shows the forward current gain after extracting  $V_{dC}$  and optimizing  $V_{er}$ ,  $V_{ef}$ ,  $I_S$  and  $dE_g$ , their values are given in Table 4.13.



Figure 4.17: Measured (markers) and simulated (line) forward current gain  $h_{fe}$  after the extraction of  $V_{dC}$ , generated by parameters in Table 4.13.

We also want to make sure that the temperature dependence of  $h_{fe}$  is good, for they can give correct current at different temperatures. The temperature scaling rules of  $I_S$  is given in equation (4.37). The temperature dependence of  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  are given as:

$$V_{efT} = V_{ef} t_N^{A_{Q_{B0}}} \left[ (1 - X_p) \left( \frac{V_{d_C}}{V_{d_C T}} \right)^{p_C} + X_p \right]^{-1},$$
(4.55)

$$V_{erT} = V_{er} t_N^{A_{Q_{B0}}} \left(\frac{V_{d_E}}{V_{d_ET}}\right)^{-p_E},$$
(4.56)

#	parameter	value	comment
1	$V_{gB}$	1.162	
2	V <sub>gC</sub>	1.137	
3	V <sub>gE</sub>	1.113	
4	A <sub>QB0</sub>	366.3m	

Table 4.14: Temperature scaling parameters optimized here, used to generate Figure 4.18 and Figure 4.19.

$$dE_{gT} = dE_g t_N^{A_{QB0}},\tag{4.57}$$

therefore the temperature scaling parameters  $V_{gB}$ ,  $V_{gC}$ ,  $V_{gE}$  and  $A_{QB0}$  are optimized by fitting  $h_{fe}$  at different temperatures as shown in Figure 4.18.



Figure 4.18:  $h_{fe}$  at different temperatures, generated by parameters in Table 4.14.

We also need to check forward collector current at different temperatures because  $I_S$  has been changed.  $I_C$  barely changes as shown in Figure 4.19. The parameters used here are shown in Table 4.14.



Figure 4.19: Gummel plots check after extracting parameters of  $h_{fe}$ , generated by parameters in Table 4.14.

## 4.5 Low current output plots check

Output curves are important since they are used to extract the self-heating parameters and high current parameters. In this section, the output curves of forced low  $I_B$  and forced low  $V_{BE}$  are inspected in order to verify the extraction results of former parameters. The results are shown in Figure 4.20.

 $I_C$  curve is not good in forced- $V_{BE} I_C - V_{CE}$  plot, so the parameters used to describe  $I_C$ , which are  $I_S$ ,  $V_{er}$ ,  $V_{ef}$  and  $dE_g$ , need to be optimized. When adjusting these parameters, we also need to optimize  $I_{BI}$  to keep forced- $I_B I_C - V_{CE}$  fitted. Thus  $I_S$ ,  $I_{BI}$ ,  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  are optimized by fitting these output curves of low currents, forward collector and base currents, hfe as well as  $F_{fwdearly}$  as shown in Figure 4.21. The value of  $I_S$ ,  $I_{BI}$ ,  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  are listed in Table 4.15.



Figure 4.20: Low current output characteristics at 300 K.

#	parameter	value	comment
1	l <sub>S</sub>	3.429a	
2	I <sub>BI</sub>	1.449e-20	
3	$V_{ef}$	10.77	
4	$V_{er}$	5.183	
5	$dE_{g}$	90.02m	

Table 4.15: Parameters used to fit low current output curves, used to generate Figure 4.21.

Since the value of  $I_S$ ,  $I_{BI}$ ,  $V_{er}$ ,  $V_{ef}$  and  $dE_g$  have been changed, their related temperature scaling coefficients are also optimized here, as shown in Figure 4.22. Here we optimize  $V_{gB}$ ,  $V_{gE}$  and  $A_{QB0}$  by fitting forward  $I_C$  and  $I_B$  as well as current gain. The value of  $V_{gB}$ ,  $V_{gE}$  and  $A_{QB0}$  are given in Table 4.16.

At high  $V_{CE}$ , the simulated  $I_C$  and  $V_{BE}$  and their measured data split. It is because the avalanche parameter  $I_{TOavl}$  which is used for high currents is not extracted yet. Therefore

#	parameter	value	comment
1	V <sub>gB</sub>	1.123	
2	V <sub>gE</sub>	1.125	
3	A <sub>QBO</sub>	716.2m	

Table 4.16: Temperature scaling parameters used in fitting low current output curves, used to generate Figure 4.22.



Figure 4.21: Fitting low current output characteristics at 300 K, generated by parameters in Table 4.15.

ſ	#	parameter	value	comment
	1	I <sub>TOavl</sub>	6.54m	

Table 4.17: Parameter  $I_{TOavl}$  used to generate Figure 4.23.

 $I_{TOavl}$  is optimized by fitting these output curves of low currents, along with  $I_{avl}$  and  $G_{EM}$ , as shown in Figure 4.23. The value of  $I_{TOavl}$  is given in Table 4.17.



Figure 4.22: Gummel plots check and current gain check after extracting parameters of low current output characteristics, generated by parameters in Table 4.16.



Figure 4.23: Low current output characteristics fitting, generated by parameter in Table 4.17.

## Chapter 5

## **Extraction of High Current Parameters**

The extraction of high current parameters is not as straightforward as that of low current parameters. In this chapter, we first discuss self-heating, then we extract the parameters of forced high  $I_B$  and forced high  $V_{BE}$  output curves and the related temperature scaling parameters. Last, parameters of cut-off frequency and temperature scaling of those parameters are extracted.

## 5.1 Extraction of parameters of self-heating and output characteristics at 300 K

The extraction of self-heating parameters should be done properly in order to extract the highcurrent parameters correctly, for self-heating can distort the measurement at high currents and voltages as we discussed in former steps. The thermal resistance  $R_{TH}$  is critical for the modeling of self-heating because the junction temperature is determined by  $R_{TH}$ , and therefore the temperature characteristics of the whole device.  $R_{TH}$  is extracted from the base-emitter voltage in the output curve  $V_{BE}$ - $V_{CE}$ , of which the base current is a constant value.

The temperature will rise due to self-heating by an amount given as:

$$\Delta T = R_{TH} (I_B V_{BE} + I_C V_{CE}). \tag{5.1}$$

Obviously, the collector part contributes significantly to self-heating. At small  $V_{CE}$  and  $I_B$ , self-heating can be neglected so the base-emitter voltage is a constant. As  $V_{CE}$  and  $I_B$  increase, self-heating effect becomes more and more important.  $I_B$  is dominated by the ideal base current

 $I_{BI}$  and it can be approximated by:

$$I_B = I_{BIT} e^{V_{B_2 E_1} / (N_{BI} V_T)}.$$
(5.2)

From now on, we need to temperature scaled model parameters, because the currents and voltages are high.  $I_{BIT}$ , as we discussed in 4.4.4, increases with increasing temperature.  $V_{CE}$ increases rapidly in output measurement and causes the increase of temperature, which leads to the increase of  $I_{BIT}$ . Then  $V_{BE}$  needs to be decrease to keep  $I_B$  constant for a forced  $I_B$  output measurement.  $R_{TH}$  is extracted from this decrease of  $V_{BE}$ .

From equation (5.2) the internal junction voltage  $V_{B_2E_1}$  can be expressed as:

$$V_{B_2 E_1} = N_{BI} V_T \ln(\frac{I_B}{I_{BIT}}).$$
(5.3)

The external base-emitter voltage  $V_{BE}$  also includes voltage drops over resistance, of which the most important is  $R_E$ , and it can be approximated by:

$$V_{BE} = N_{BI} V_T \ln(\frac{I_B}{I_{BIT}}) + I_C R_{ET},$$
(5.4)

 $R_E$  is the emitter resistance we extracted in 4.4.3. Since it presents in the equation of  $V_{BE}$ , we need to optimize its value here for a good description of output curves. Thus,  $R_{TH}$  and  $R_E$  are both extracted from output measurement  $V_{BE}$ - $V_{CE}$  as shown in Figure 5.1.

Other parameters used to describe output characteristics are extracted from forced  $I_B I_C$ - $V_{CE}$  curves. To understand extraction of these parameters, we consider calculating the collector current in terms of the base current  $I_B$  and the collector bias  $V_{CE}$ , following [11]. The collector current  $I_C$  is written as:

$$I_{C_1C_2} = I_N = I_S \frac{e^{V_{B_2E_1}/V_T} - e^{V_{B_2C_2}^*/V_T}}{q_B^I}.$$
(5.5)

 $q_B^I$ ,  $V_{B_2E_1}$  and  $V_{B_2C_2}^*$  should be calculated to get  $I_{C_1C_2}$ .  $V_{B_2C_2}^*$  is the bias considering quasisaturation.  $V_{B_2E_1}$  can be obtained by equation 5.2 from base current.  $q_B^I$  can be calculated



Figure 5.1:  $V_{BE}$  -  $V_{CE}$  under forced high  $I_B$ 

by:

$$q_B^I = q_1^I (1 + 0.5n_0 + 0.5n_B), (5.6)$$

 $q_1^I$  is defined in (4.21).  $n_0$  and  $n_B$  are the base minority electron densities at the emitter edge and at the collector edge, and they are given by:

$$f_1 = 4 \frac{I_S}{I_K} e^{V_{B_2 E_1}/N_{FF} V_T},$$
(5.7)

$$n_0 = \frac{f_1}{1 + \sqrt{1 + f_1}},\tag{5.8}$$

$$f_2 = 4 \frac{I_S}{I_K} e^{V_{B_2 C_2}^*/N_{FR} V_T},$$
(5.9)

$$n_B = \frac{f_2}{1 + \sqrt{1 + f_2}}.$$
(5.10)

 $V_{B_2C_2}^*$  is solved iteratively from  $I_{C_1C_2}$ . First, the voltage and current at which quasi-saturation start are given as

$$V_{qs}^{th} = V_{d_CT} + 2V_T \ln(\frac{I_{C_1C_2}R_{CVT}}{2V_T} + 1) - V_{B_2C_1},$$
(5.11)

$$V_{qs} = 0.5(V_{qs}^{th} + \sqrt{(V_{qs}^{th})^2 + 4(0.1V_{d_CT})^2}),$$
(5.12)

$$I_{qs} = \frac{V_{qs}}{SCR_{CV}} \frac{V_{qs} + I_{hc}SCR_{CV}}{V_{qs} + I_{hc}R_{CVT}},$$
(5.13)

 $SCR_{CV}$  is the space charge resistance of epilayer.  $I_{hc}$  is the critical current for velocity saturation in the epilayer. The internal voltage  $V_{B_2C_1}$  in equation 5.11 is calculated by:

$$V_{B_2C_1} = V_{B_2E_1} + I_C R_{CCT} + (I_B + I_C)R_{ET} - V_{CE}.$$
(5.14)

Then we can get  $\alpha$  expressed as:

$$\alpha = \frac{1 + a_{Xi} \ln(1 + \exp[(I_{C_1 C_2} / I_{qs} - 1) / a_{Xi}])}{1 + a_{Xi} \ln(1 + \exp[-1 / a_{Xi}])},$$
(5.15)

 $a_{Xi}$  is the smoothness parameter for onset of quasi-saturation.

We need to solve

$$\alpha I_{qs} = \frac{V_{qs}}{SCR_{CV}y_i^2} \frac{V_{qs} + I_{hc}SCR_{CV}y_i}{V_{qs} + I_{hc}R_{CVT}},$$
(5.16)

which leads to

$$v = \frac{V_{qs}}{I_{hc}SCR_{CV}},\tag{5.17}$$

$$y_i = \frac{1 + \sqrt{1 + 4\alpha v(1 + v)}}{2\alpha(1 + v)}.$$
(5.18)

The injection thickness is given by:

$$\frac{x_i}{W_{epi}} = 1 - \frac{y_i}{1 + p_W y_i},\tag{5.19}$$

the hole density  $p_0^*$  at the base-collector junction is expressed by:

$$g = \frac{I_{C_1 C_2} R_{CVT}}{2V_T} \frac{x_i}{W_{epi}},$$
(5.20)

$$p_0^* = \frac{g-1}{2} + \sqrt{\left(\frac{g-1}{2}\right)^2 + 2g + p_W(p_W + g + 1)},$$
(5.21)

$$e^{V_{B_2C_2}^*/V_T} = p_0^*(p_0^* + 1)e^{V_{d_CT}/V_T}.$$
(5.22)

The internal base-collector bias is obtained from equations involved for finding  $I_C$  from a given  $I_B$ , outlined above. We see that  $I_K$ ,  $SCR_{CV}$ ,  $R_{CV}$ ,  $I_{hc}$ , and  $a_{Xi}$  are most important parameters.  $R_{CV}$ ,  $V_{d_C}$ ,  $R_E$ ,  $R_{CC}$ , which are parameters estimated in former steps, need to be optimized here in order to give good description of output characteristics, while  $I_K$ ,  $SCR_{CV}$ ,  $I_{hc}$ , and  $a_{Xi}$  are extracted the first time.



Figure 5.2:  $T_k$  of forced high  $I_B$  at 300 K

 $T_K$  shown in Figure 5.2 illustrates that self-heating needs to be taken into account in high bias output measurement. Therefore, temperature-scaling needs to be done here. Since all the related temperature scaling parameters except  $A_B$  already have good estimation from former extractions,  $A_B$ , which is fairly important, is extracted here. The significance of  $A_B$  can be seen in equations:

$$I_{sT} = I_s t_N^{\frac{4-A_B - A_{QB0} + DAIS}{N_{FF}}} \exp[-\frac{V_{gB}}{N_{FF} V_{\Lambda T}}],$$
(5.23)

$$I_{kT} = I_k t_N^{1-A_B}.$$
 (5.24)

Actually, high current parameters have strong correlations between each other, so it is not possible to extract them individually. The parameters such as  $I_K$ ,  $R_{CV}$  and  $I_{hc}$  which are important in extracting the parameters of  $I_C$  also have obvious influences on  $V_{BE}$ . Therefore, we extract output parameters by fitting  $I_C$ - $V_{CE}$  and  $V_{BE}$ - $V_{CE}$  curves together as shown in





Figure 5.3:  $I_C$ - $V_{CE}$  and  $V_{BE}$ - $V_{CE}$  plots of forced high  $I_B$  at 300 K

As we can see, at low  $V_{CE}$  (around 0V-2V) the simulated  $I_C$  and  $I_B$  fit well with the measured data in forced  $V_{BE}$  measurement. When  $V_{CE}$  further rises, the simulated data increases rapidly and then reaches to a plateau. This is because the thermal resistance  $R_{th}$  is overestimated so that the voltage of temperature node  $V_{dT}$  reaches its upper limit defined by the Mextram 505 code and it cannot be increased any more.  $T_K$ , therefore, also stops rising.  $T_K$  of forced high  $V_{BE}$  is shown in Figure 5.5.

The value of  $T_k$  is too high and reaches its limit as shown in Figure 5.5. Figure 5.4 shows that in forced  $V_{BE} I_C - V_{CE}$  curves, the simulated data is larger than measured data at high  $V_{CE}$ , so the value of  $R_{th}$  is a bit large. Therefore  $R_{th}$  is reduced and all the other parameters are adjusted to fit output plots. The extraction results are shown in Figure 5.6.



Figure 5.4: Output plots of forced high  $I_B$  and forced high  $V_{BE}$  at 300 K



Figure 5.5:  $T_k$  of forced high  $V_{BE}$  at 300 K



Figure 5.6: Output plots of forced high  $I_B$  and forced high  $V_{BE}$  at 300 K

After extracting all output parameters, it is necessary to look back at the Gummel plots, for resistance  $R_E$ ,  $R_{CC}$  and  $R_{CV}$  have been changed to fit output curves. The Gummel plots are shown in Figure 5.7.



Figure 5.7: Gummel plots after extraction of output plots at 300 K

As can be seen from the figure, there is just a small change in the forward Gummel plots, but the reverse Gummel plots are quite different from the previous ones. This is because the resistance  $R_E$ ,  $R_{CV}$  and  $R_{CC}$  are used in the extraction of both Gummel measurement and output measurement. The influence of  $R_{CC}$  and  $R_{CV}$  in reversed Gummel plots is greater than that of forward Gummel plots. The effect of  $R_E$  is opposite. However, the variation of  $R_E$ is small so the influence of  $R_E$  on forward Gummel plots could be ignored. Therefore, the changes of reverse Gummel plots are more apparent. Trying to fit all plots more desirable, the resistance  $R_{CV}$  and  $R_{CC}$  are optimized by fitting the reverse Gummel plots at high  $V_{BC}$  and output plots together as shown in Figure 5.8. The values of parameters used here are listed in Table 5.1.



Figure 5.8: Optimize  $R_{CV}$  and  $R_{CC}$  by fitting reverse Gummel plots and high current output plots together at 300 K, generated by parameters in Table 5.1.

#	parameter	value	comment
1	R <sub>E</sub>	14.83	
2	R <sub>th</sub>	4.543k	
3	R <sub>cc</sub>	28.98	
4	R <sub>CV</sub>	101.6	
5	A <sub>B</sub>	799.3m	
6	I <sub>K</sub>	17.08m	
7	SCR <sub>CV</sub>	76.14	
8	I <sub>hc</sub>	18.82m	
9	a <sub>Xi</sub>	181.4m	

Table 5.1: Parameters extracted from high current output curves and reverse currents in Gummel measurement, used to generate Figure 5.8.

#### 5.2 Temperature scaling of DC high current parameters

After extracting parameters of output characteristics at 300 K, the temperature scaling parameters are extracted by fitting all the  $I_C$  -  $V_{CE}$  and  $V_{BE}$  -  $V_{CE}$  plots at different temperatures at the same time, as shown in Figure 5.9. The parameters optimized in high current output plots include  $A_C$ ,  $A_B$ ,  $A_{EPI}$ ,  $A_{EX}$ , DAIS,  $A_{QBO}$  and  $A_E$  from former extractions in section 4.4.4.  $A_{TH}$ , which is used to describe the temperature dependence of thermal resistance  $R_{TH}$ , needs to be extracted here. The values of parameters used here are given in Table 5.2.



$$R_{TH,Tamb} = R_{TH} \left(\frac{T_{amb}}{T_{RK}}\right)^{A_{TH}}.$$
(5.25)

Figure 5.9: Forced high  $I_B$  output curves at different temperatures, generated by parameters in Table 5.2.

Again, we need to check Gummel plots since the temperature scaling parameters have been changed here. As shown in Table 4.11, the change of  $A_B$ , DAIS and  $A_{QBO}$  will lead to the change of  $V_{gB}$ ; the change of DAIS and  $A_E$  will lead to the change of  $V_{gE}$ ; the change

#	parameter	value	comment
1	A <sub>epi</sub>	1.346	
2	A <sub>C</sub>	-1.467	
3	A <sub>B</sub>	1.485	
4	A <sub>EX</sub>	366.8m	
5	A <sub>QBO</sub>	10.77m	
6	DAIS	399.9m	
7	A <sub>E</sub>	-753.0u	
8	$A_{th}$	431.8m	

Table 5.2: Temperature scaling parameters used in fitting high current output curves to generate Figure 5.9.

#	parameter	value	comment
1	$V_{gB}$	1.139	
2	$V_{gE}$	1.136	
3	A <sub>CX</sub>	1.674	
4	$V_{gCX}$	1.136	

Table 5.3: Temperature scaling parameters extracted from Figure 5.10.

of DAIS will lead to the change of  $A_{CX}$  and  $V_{gCX}$ . Therefore,  $V_{gB}$ ,  $V_{gE}$ ,  $A_{CX}$  and  $V_{gCX}$  are optimized by fitting high current output curves and Gummel plots at different temperatures as shown in Figure 5.10. The values of these parameters are given in Table 5.3.

Since  $V_{gB}$ ,  $V_{gE}$  and  $A_{QBO}$ ,  $A_B$ , DAIS and  $A_E$  have been changed here, we also need to check the values of  $I_{ST}$  and  $I_{BIT}$ , which are saturation currents influenced by these parameters. We inspect  $I_{ST}$  and  $I_{BIT}$  from low current output curves at different temperatures as shown in Figure 5.11.

The figure shows that at 300 K the low current output curves fit well, but at 223 K and 393 K their fittings need to be improved. Therefore,  $V_{gB}$ ,  $V_{gE}$ ,  $A_{QBO}$ ,  $A_B$ , DAIS, and  $A_E$ , which are temperature scaling parameters used to describe base and collector currents are optimized by fitting low current output plots with high current output curves, as well as forward  $I_B$  and  $I_C$  from Gummel measurement at different temperatures simultaneously, as shown in Figure 5.12. The values of parameters optimized here are also given in Table 5.4.

Since DAIS has been changed again,  $A_{CX}$  and  $V_{gCX}$  may also have been changed either or not. These two parameters are optimized by fitting  $I_S$  and  $I_B$  in reverse Gummel measurement at different temperatures as shown in Figure 5.13. In this figure we also plot high current



Figure 5.10: Gummel plots check with output curves at different temperatures, generated by parameters in Table 5.3.

output curves to show that  $A_{CX}$  and  $V_{gCX}$  have small impacts on them. The values of  $A_{CX}$  and  $V_{gCX}$  are given in Table 5.5.



Figure 5.11: Low current output plots check at different temperatures.

#	parameter	value	comment
1	A <sub>B</sub>	1.487	
2	A <sub>QBO</sub>	144.4m	
3	DAIS	20.38m	
4	A <sub>E</sub>	-589.3u	
5	$V_{gB}$	1.142	
6	V <sub>gE</sub>	1.149	

Table 5.4: Parameters used in low current output plots fitting with high current output plots and forward Gummel curves at different temperatures, used to generate Figure 5.12.

#	parameter	value	comment
1	A <sub>CX</sub>	1.39	$A_{CX}$ in Figure 5.13
2	$V_{gCX}$	1.133	$V_{gCX}$ in Figure 5.13

Table 5.5: Parameters used in fitting  $I_S$  and  $I_B$  in reverse Gummel measurement with high current output curves at different temperatures, extracted from Figure 5.13.



Figure 5.12: Low current output plots fitting with high current output plots and forward Gummel curves at different temperatures, generated by parameters in Table 5.4.



Figure 5.13: Fitting  $I_S$  and  $I_B$  in reverse Gummel measurement with high current output curves at different temperatures, generated by parameters in Table 5.5.

## 5.3 DC extraction check

It is necessary to take a look at all the extraction results at the same time after extracting all DC electric and temperature-scaling parameters, to make sure that all DC parameters have reasonable value. First, we look at important plots of DC low current extraction at 300 K shown in Figure 5.14. The Gummel characteristics after temperature scaling are shown in Figure 5.15. The output curves under forced low  $I_B$  and forced low  $V_{BE}$  after temperature scaling are shown in Figure 5.16. The output curves of forced high  $I_B$  and forced high  $V_{BE}$  after temperature scaling are shown in Figure 5.17.



Figure 5.14: DC low current extraction results at 300 K.



Figure 5.15: Gummel plots after temperature scaling.



Figure 5.16: Low current output curves after temperature scaling.



Figure 5.17: High current output curves after temperature scaling.

#### 5.4 Cut-off frequency at 300 K

The cut-off frequency  $f_T$  is defined as the frequency at which the current gain  $h_{fe}$  reduces to unity. The current gain can be expressed in terms of Y-parameters as:

$$h_{fe} = h_{21} = \frac{Y_{21}}{Y_{11}},\tag{5.26}$$

 $f_T$  is calculated by:

$$f_T = \frac{f}{Im(1/h_{fe})},$$
 (5.27)

this equation is used to calculate  $f_T$  for both high and intermediate frequencies. Again, to understand how to extract transit times we need to caluculate  $f_T$  following [11].  $f_T$  can be determined in terms of  $I_C$  as:

$$\frac{1}{2\pi f_T} = \tau_T = \frac{dQ}{dI_C}|_{V_{CE}},$$
(5.28)

 $\tau_T$  is the total emitter-collector transit time. It is related to the differential charge dQ and the differential current  $dI_C$ , both under a constanct collector-emitter bias  $V_{CE}$ . To solve this equation, we first need to know the variation of the internal biases  $V_{B_2E_1}$ ,  $V_{B_2C_1}$  and the collector current  $I_{C_1C_2}$ .  $V_{B_2E_1}$  is calculated by equation(5.2),  $V_{B_2C_1}$  is evaluated from equation(5.14), the collector current  $I_{C_1C_2}$  is discribed by equation (5.5). Thus we have:

$$dV_{CE} = \frac{\partial V_{CE}}{\partial V_{B_2E_1}} dV_{B_2E_1} + \frac{\partial V_{CE}}{\partial V_{B_2C_1}} dV_{B_2C_1} + \frac{\partial V_{CE}}{\partial I_{C_1C_2}} dI_{C_1C_2} = 0,$$
(5.29)

$$dI_N = \frac{\partial I_N}{\partial V_{B_2 E_1}} dV_{B_2 E_1} + \frac{\partial I_N}{\partial V_{B_2 C_1}} dV_{B_2 C_1} + \frac{\partial I_N}{\partial I_{C_1 C_2}} dI_{C_1 C_2} = dI_{C_1 C_2},$$
(5.30)

$$dQ = \frac{\partial Q}{\partial V_{B_2 E_1}} dV_{B_2 E_1} + \frac{\partial Q}{\partial V_{B_2 C_1}} dV_{B_2 C_1} + \frac{\partial Q}{\partial I_{C_1 C_2}} dI_{C_1 C_2}.$$
(5.31)

Therefore, most of the parameters we extracted from output characteristics are optimized here.  $V_{dC}$  is also optimized here as we discussed in 4.4.5, for it can influence current gain. How these parameters influence the simulated results are shown in Figure 5.18 - Figure 5.25. The parameters,  $R_E$ ,  $R_{th}$ ,  $I_K$ ,  $I_{hc}$ ,  $SCR_{CV}$ ,  $a_{Xi}$ ,  $R_{CC}$ ,  $R_{CV}$  and  $V_{dC}$  are simulated on output characteristics and cut-off frequency separately. Each time only one parameter is changed so

#	parameter	value	comment
1	R <sub>E</sub>	14.81	
2	R <sub>th</sub>	4.56k	
3	R <sub>cc</sub>	31.89	
4	R <sub>CV</sub>	99.13	
5	Ι <sub>κ</sub>	18.14m	
6	SCR <sub>CV</sub>	1.025k	
7	I <sub>hc</sub>	18.65m	
8	a <sub>Xi</sub>	157.5m	
9	$V_{d_C}$	884.0m	
10	mtau	1.182	
11	taue	519.9f	
12	taub	497.5f	
13	tepi	790.5f	
14	taur	64.66n	

Table 5.6: Parameters extracted from fitting cut-off frequency curves, high current output curves and  $h_{fe}$ , as shown in Figure 5.27.

we can observe the impact of parameters individually. Measured data are indicated by black markers, well-extracted values are represented by solid red lines and curves after changing one parameter are indicated by solid blue lines.

Thus, transit times are extracted along with output plots and  $h_{fe}$  curve. Transit times including  $\tau_E$ ,  $\tau_B$ ,  $\tau_R$ ,  $\tau_{epi}$ , and non-ideality factor of emitter stored charge  $m_{\tau}$  are used to describe charges. The maximum  $f_T$  at high bias is used to extract  $\tau_E$  and  $\tau_B$ .  $\tau_{epi}$ ,  $I_{hc}$  and  $SCR_{CV}$  are extracted from the degradation of  $f_T$ . We do the extraction at different  $V_{CB}$  to get meaningful parameters that can be used for various bias.  $f_T - V_{CB}$  at different bias are shown in Figure 5.27. Values of parameters used here are given in Table 5.6.

We also need to check Gummel plots since the value of  $R_E$ ,  $R_{CC}$  and  $R_{CV}$  have been changed. Figure 5.28 shows that the Gummel curves barely changes, so we do not need to optimize these resistances again.


Figure 5.18: Impact of parameter  $R_E$  on output characteristics and  $f_T$ 



Figure 5.19: Impact of parameter  $R_{TH}$  on output characteristics and  $f_T$ 



Figure 5.20: Impact of parameter  $I_K$  on output characteristics and  $f_T$ 



Figure 5.21: Impact of parameter  $I_{hc}$  on output characteristics and  $f_T$ 



Figure 5.22: Impact of parameter  $a_{Xi}$  on output characteristics and  $f_T$ 



Figure 5.23: Impact of parameter  $R_{CC}$  on output characteristics and  $f_T$ 



Figure 5.24: Impact of parameter  $R_{CV}$  on output characteristics and  $f_T$ 



Figure 5.25: Impact of parameter  $SCR_{CV}$  on output characteristics and  $f_T$ 



Figure 5.26: Impact of parameter  $V_{dC}$  on output characteristics and  $f_T$ 



Figure 5.27: Extraction of  $f_T$  parameters at 300 K, generated by parameters in Table 5.6.



Figure 5.28: Check Gummel curves with  $f_T$  curves at 300 K, generated by parameters in Table 5.6.

#	parameter	value	comment
1	A <sub>B</sub>	1.169	
2	A <sub>epi</sub>	1.037	
3	$dV_{gTE}$	109.2m	
4	A <sub>QBO</sub>	95.63m	

Table 5.7: Parameters used in temperature scaling of cut-off frequency, to generate Figure 5.29.

## 5.5 Temperature scaling of cut-off frequency

After doing extraction at 300 K, we need to extract the temperature scaling parameters of cutoff frequency. Transit times have temperature dependency as:

$$\tau_{ET} = \tau_E t_N^{(A_B - 2)} exp[-\mathrm{dV}_{\mathrm{g}\tau_E}/\mathrm{V}_{\Delta\mathrm{T}}], \qquad (5.32)$$

$$\tau_{BT} = \tau_B t_N^{A_{QB0} + A_B - 1} \tag{5.33}$$

$$\tau_{epiT} = \tau_{epi} t_N^{A_{epi}-1},\tag{5.34}$$

$$\tau_{RT} = \tau_R \frac{\tau_{BT} + \tau_{epiT}}{\tau_B + \tau_{epi}}.$$
(5.35)

The bandgap voltage difference of emitter stored charge  $dV_{g\tau_E}$  is extracted here.  $A_B$ ,  $A_{epi}$  and  $A_{QB0}$  are used in previous extractions and they need to be optimized here. These temperature scaling parameters can be obtained by fitting  $f_T$  plots and output plots at 223 K, 300 K and 393 K together. Since  $A_B$ ,  $A_{epi}$  and  $A_{QB0}$  also influence Gummel curves, Figure 5.29 is used to optimize these temperature scaling parameters by fitting  $f_T$  plots with high current output plots as well as related Gummel plots simultaneously. The parameters are given in Table 5.7.

As summerized in Table 4.11, we need to optimize DAIS and  $V_{gB}$  due to the change of  $A_B$  and  $A_{QB0}$ . The change of DAIS will also lead to the change of  $A_E$ ,  $V_{gE}$ ,  $A_{CX}$  and  $V_{gCX}$ . Therefore we optimize DAIS,  $V_{gB}$ ,  $A_E$  and  $V_{gE}$  by fitting all output curves and forward Gummel curves together as shown in Figure 5.30. Then we optimize  $A_{CX}$  and  $V_{gCX}$  by fitting reverse Gummel plots as shown in Figure 5.31, high current output curves are also displayed



Figure 5.29: Temperature scaling of cut-off frequency, generated by parameters in Table 5.7.

to show that  $A_{CX}$  and  $V_{gCX}$  do not have much influence on output curves. The parameters optimized here are given in Table 5.8.



Figure 5.30: Optimizing forward Gummel curves with output curves at multiple temperature, generated by parameters in Table 5.8.

#	parameter	value	comment
1	DAIS	20.38m	
2	$V_{gB}$	1.133	
3	V <sub>gE</sub>	1.149	
4	A <sub>E</sub>	-534.2u	
5	$V_{gCX}$	1.122	
6	A <sub>CX</sub>	1.099	

Table 5.8: Temperature scaling parameters optimized with high current output curves and Gummel curves, used to generate Figure 5.30 and Figure 5.31.



Figure 5.31: Optimizing reverse Gummel curves at multiple temperature, generated by parameters in Table 5.8.

## Chapter 6

## **Extraction Results**

This chapter shows important characteristics after extraction. Figure 6.1 shows curves of avalanche effect, forward and reverse currents, low current output characteristics and cut-off frequency at 300 K. Figure 6.2 presents forward and reverse currents in Gummel measurement after temperature scaling. Figure 6.3 shows high current output plots and  $f_T$  plots at different temperatures.



Figure 6.1: Important characteristics at 300 K.



Figure 6.2: Currents of Gummel measurement at different temperatures.



Figure 6.3: High current characteristics at different temperatures.

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